

# Emittance measurements and simulations at PITZ

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## Content:

- Photo Injector Test facility at DESY in Zeuthen (PITZ)
  - goals and motivation
  - setup and main components
- Emittance measurements methodic at PITZ
  - applied methods
  - single slit scan
- Beam dynamics simulations for the PITZ setup
- Emittance measurements at PITZ in 2009 and 2011
- Emittance measurements vs. simulations
- Outlook and summary

# Photo Injector Test facility at DESY in Zeuthen

The Photo Injector Test facility at DESY in Zeuthen (PITZ) focuses on the development, test and optimization of high brightness electron sources for superconducting linac driven FELs:

⇒ test-bed for FEL injectors: FLASH, the European XFEL

⇒ **small transverse emittance (~1 mm mrad @ 1 nC)**

⇒ **stable** production of short bunches with small energy spread

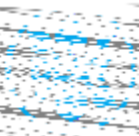
⇒ further studies: dark current, QE, thermal emittance, ...

+ **detailed comparison with simulations = benchmarking for the PI physics**


**extensive R&D** on photo injectors in parallel to **FLASH operation**

test and optimize **rf guns** for subsequent operation at the FLASH and XFEL

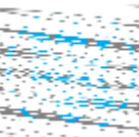
test **new developments** (laser, cathodes, beam diagnostics)



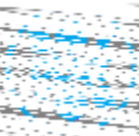
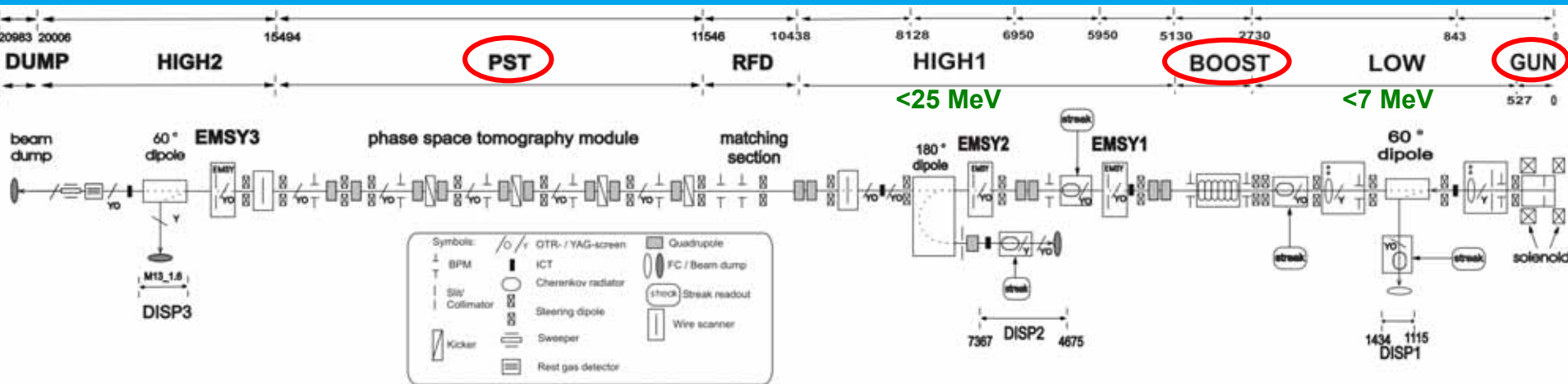
# XFEL Photo Injector Key Parameters to be tested at PITZ

subsystem	parameter	value	remarks
RF gun cavity	frequency	1.3 GHz	
	E-field at cathode	60 MV/m	dark current issue
	RF pulse duration	700 us	max
	Repetition rate	10 Hz	max
Cathode laser	Temporal → flat top → FWHM	20 ps	challenge 
	Temporal → flat top → rise/fal time	2 ps	
	Transverse – rad.homogen.XYrms	0.3-0.4 mm	fine tuning -> thermal emittance
	Pulse train length	650 us	max
	Bunch spacing	222 ns (4.5MHz)	1us (1MHz) at PITZ now
	Repetition rate	10 Hz	max
Electron beam	Bunch charge	1 nC	other charges under consideration
	Projected emittance at injector	0.9 mm mrad	
	Bunch peak current	5 kA	after bunch compression (not at PITZ)
	Emittance (slice) at undulator	1.4 mm mrad	

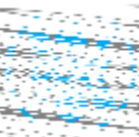
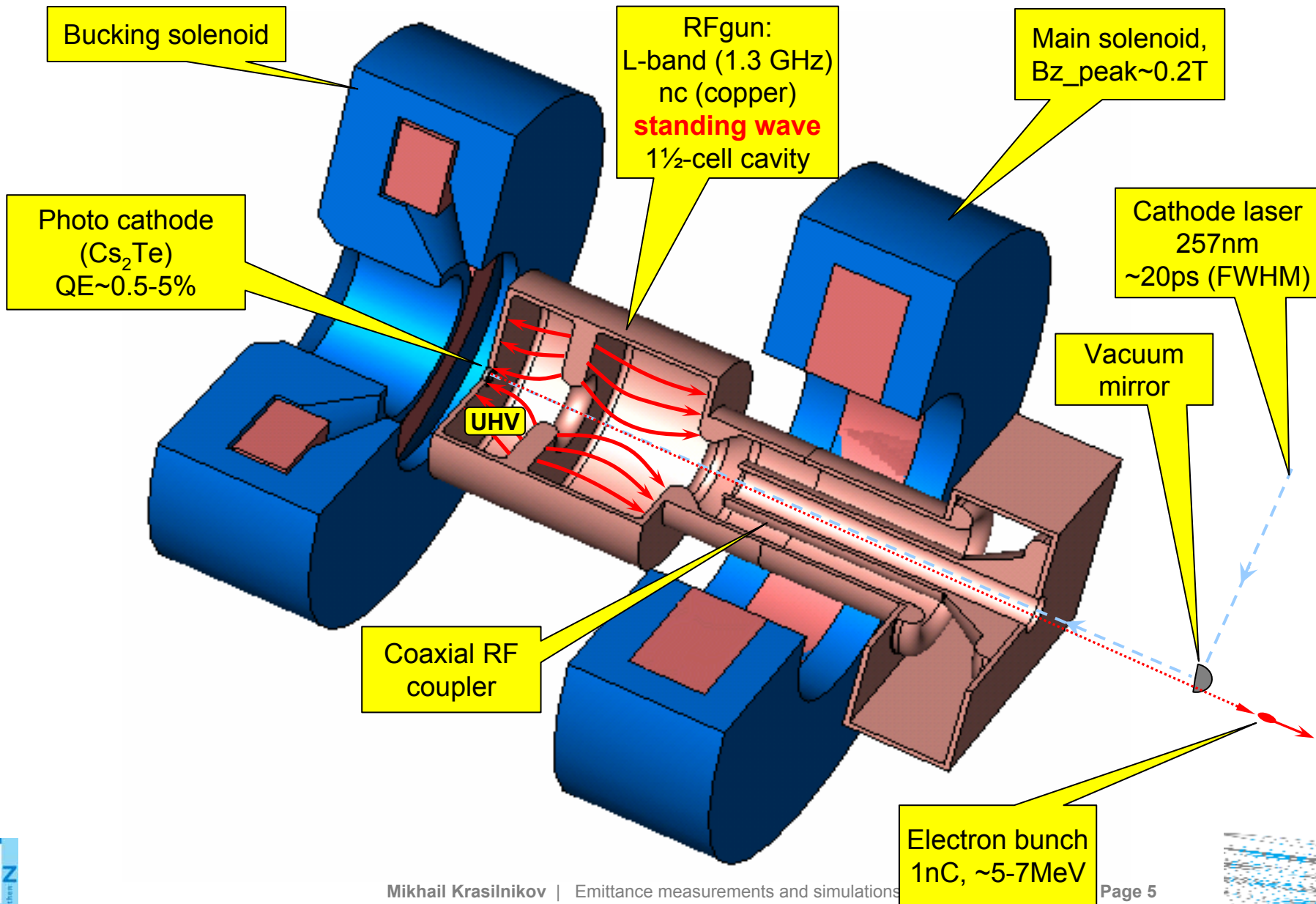
**Main efforts at PITZ towards XFEL photoinjector**



# PITZ-1.8 setup



# PITZ RF-Gun



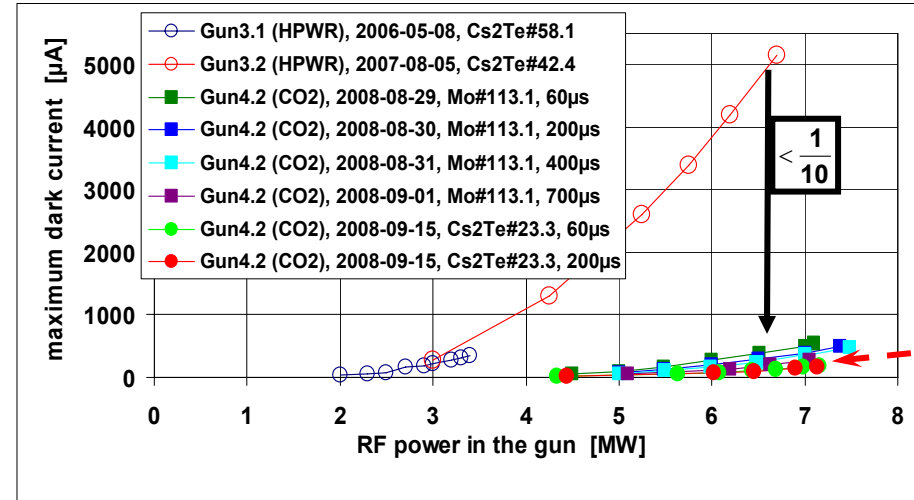
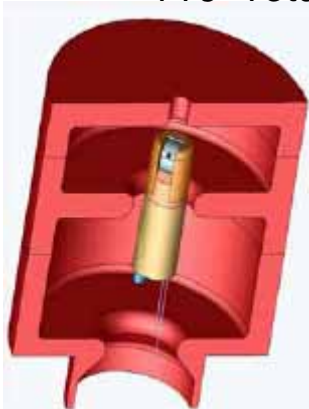
# PITZ-1.7: New Gun-4.2

Dry-ice sublimation-impulse cleaning → **significant dark current reduction**

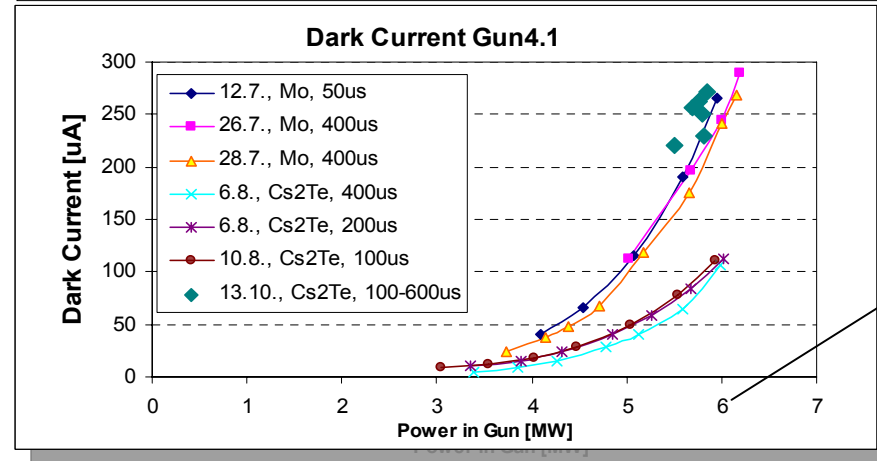
## Dark current measurements



Vertical cleaning setup with 110° rotating nozzle.

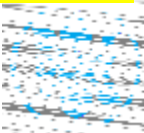


50 kW average RF power



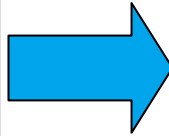
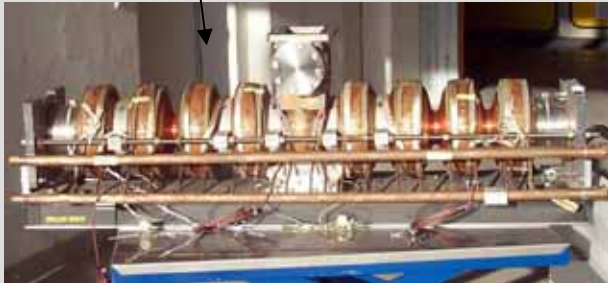
Pz~6.8MeV/c

allows high brightness, high average current operation: 1–5 mA in 700 µs, 7–35 µA long term average

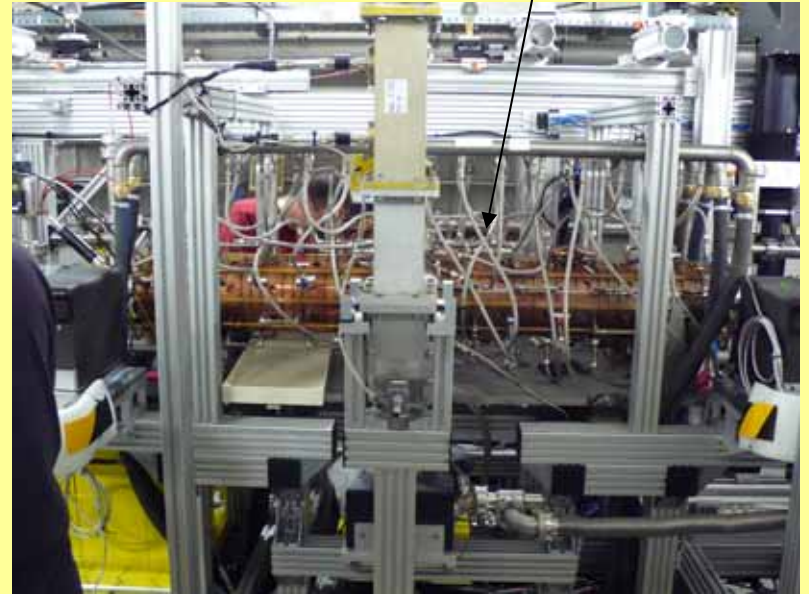


# CDS-booster

Old **TESLA**-booster has been replaced with a specially designed for PITZ **CDS**-booster



- restricted peak gradient (final beam momentum  $\sim 13\text{MeV}/c$ )
- short RF pulses only (50-100 $\mu\text{s}$ )

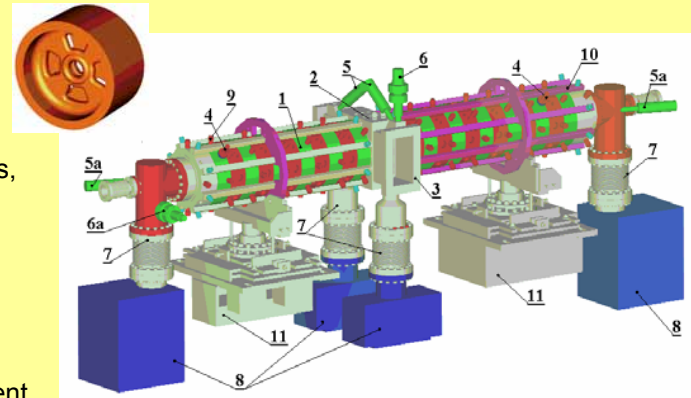


## CDS = Cut-Disc-Structure

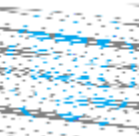
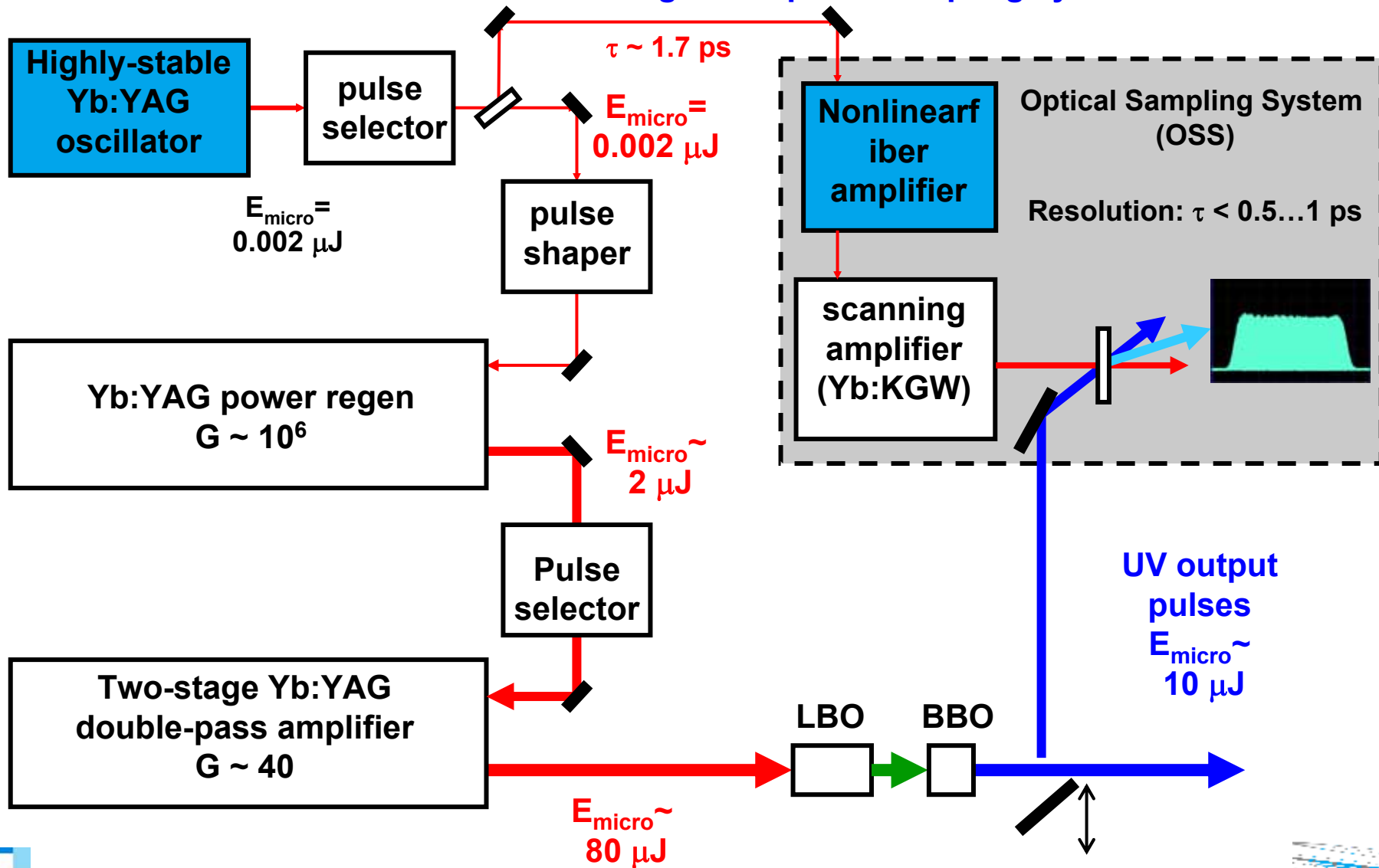
- improved water cooling system
- higher peak gradients (final beam momentum  $\sim 25\text{MeV}/c$ )
- long RF pulses (up to 700 $\mu\text{s}$ )
- longer acceleration ( $L \sim 1.4\text{m}$ )
- precise phase and amplitude control (RF probes)

Booster schematic cavity layout.

- 1 - regular cells,
- 2 - rf coupler, 3 - rf flanges,
- 5, 5a - photo multipliers,
- 6, 6a- vacuum gauges,
- 7 - pumping ports,
- 8 - ion pumps,
- 9 - internal cooling circuit,
- 10 - outer cooling circuit,
- 11 - support and adjustment.

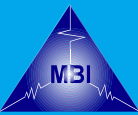


## Yb:YAG laser at PITZ with integrated optical sampling system

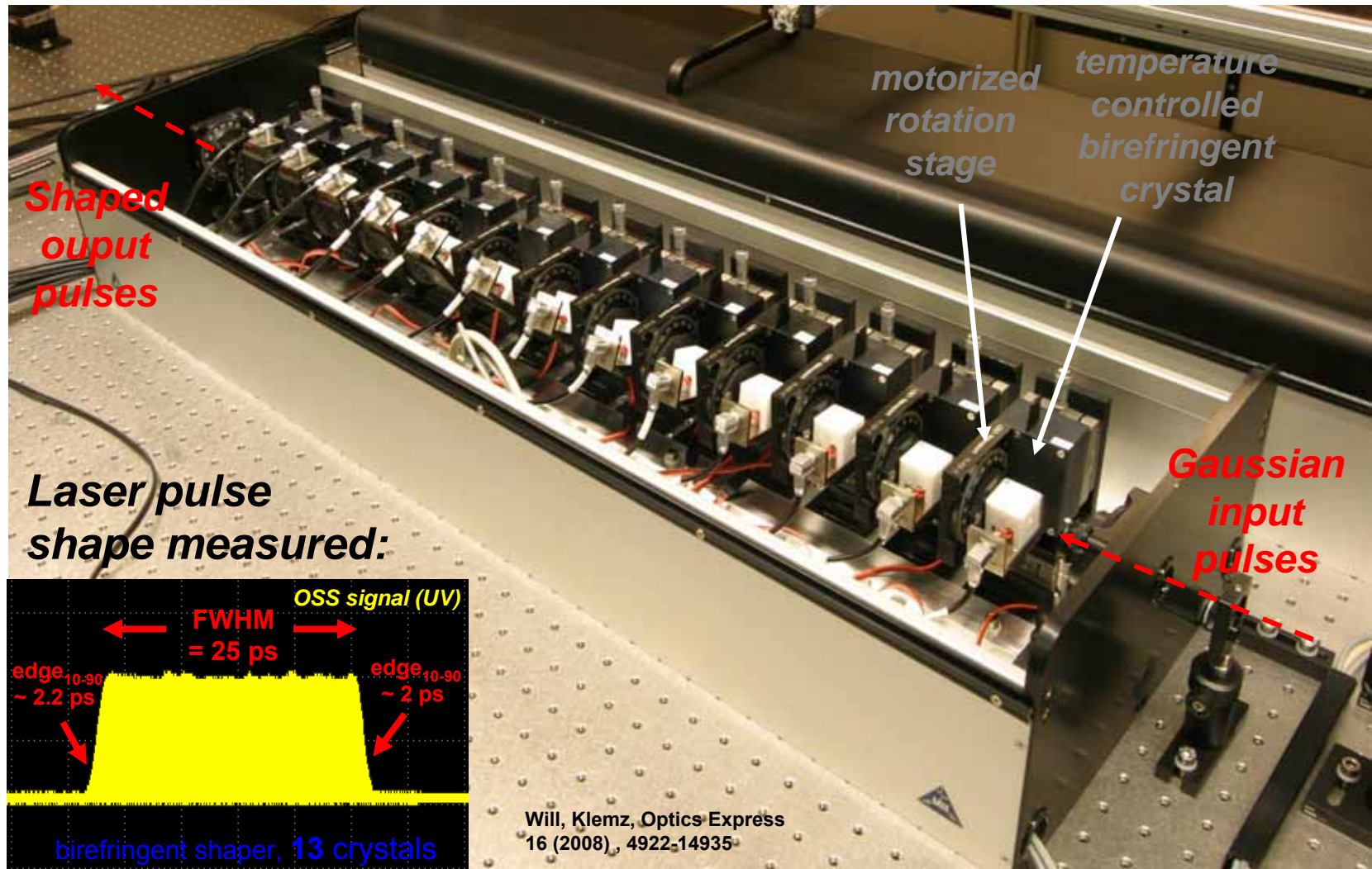




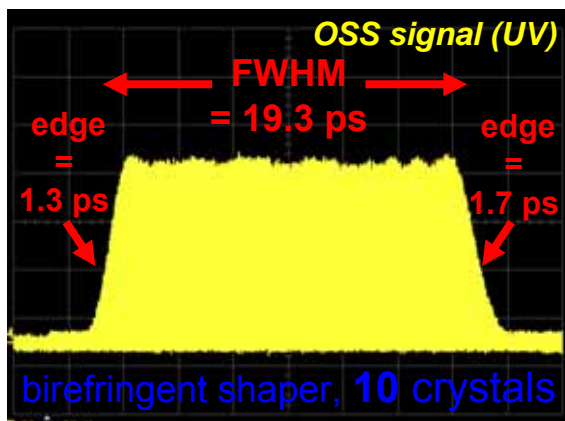
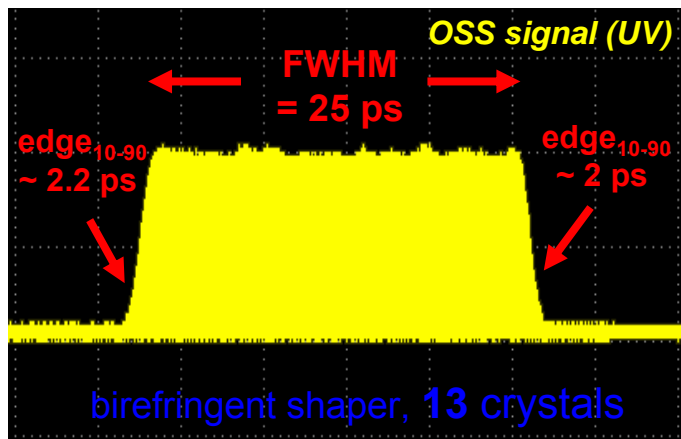
# Photo cathode laser: temporal pulse shaping



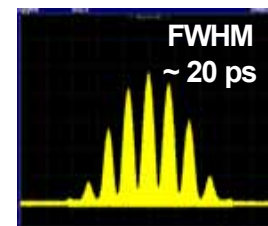
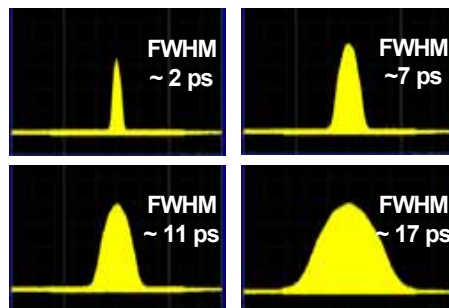
Multicrystal birefringent pulse shaper containing 13 crystals



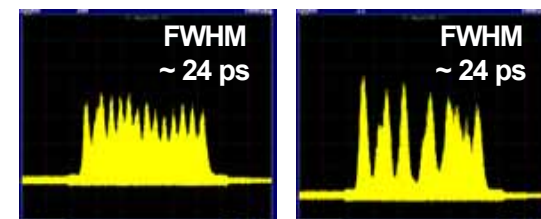
UV pulses of different shapes can be produced at the PITZ photo cathode



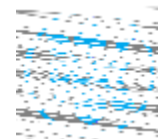
*Gaussian:*



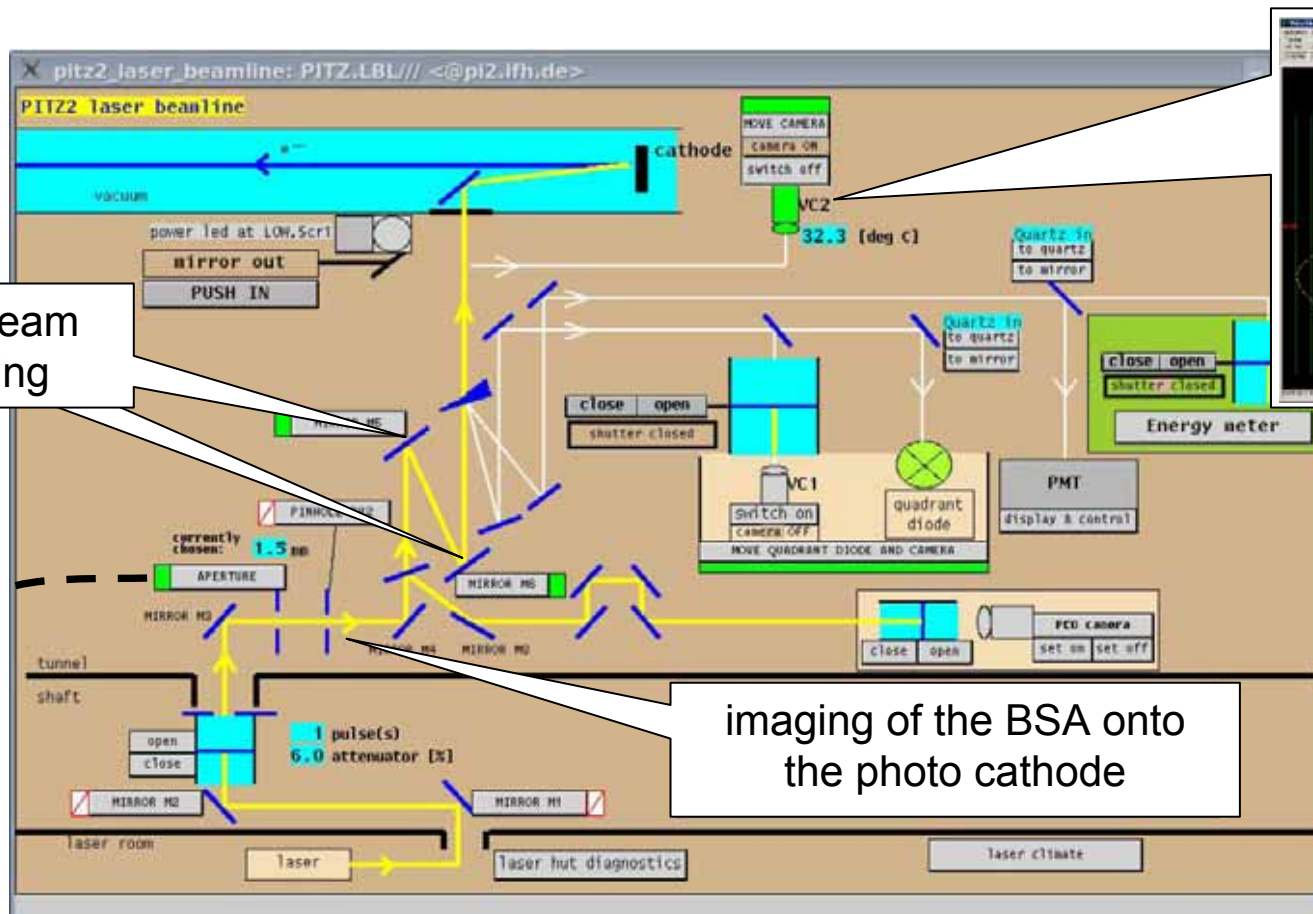
*Simulated pulse-stacker*



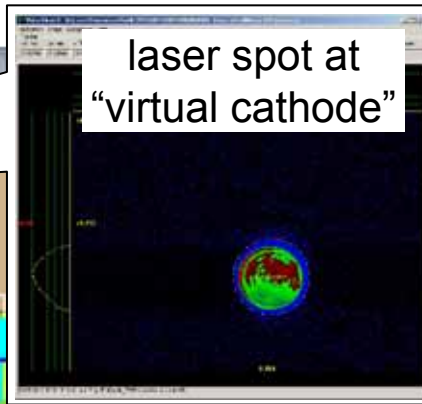
→ High flexibility of photo cathode laser system



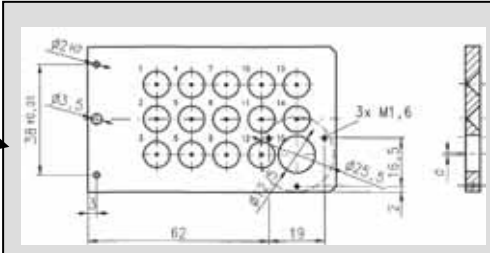
# Photo cathode laser: transverse pulse shaping



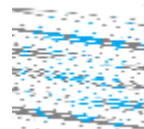
laser beam steering



imaging of the BSA onto the photo cathode

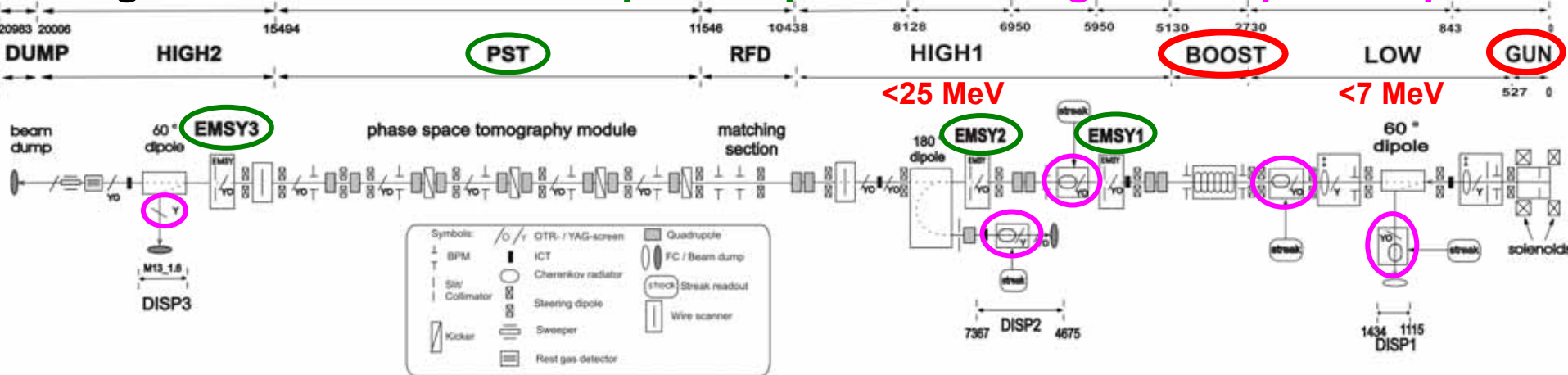


Beam Shaping Aperture (BSA) plate is now replaced by an iris with remotely tunable opening

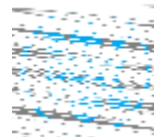


# Beam diagnostics at PITZ

## Diagnostics for Transverse phase space and Longitudinal phase space



Component	Property	Diagnostics
Cathode laser	temporal profile	OSS, streak-camera
	transverse distribution	Virtual cathodes, CCD cameras
	pulse energy	Energy-meter, PMT
	position stability	Quadrant-diode
Electron beam	bunch charge	Faraday cups, Integrating current transformers
	beam position	BPMs
	longitudinal momentum	Dipoles+ dispersive arms (LEDA, HEDA1,2)
	transverse distribution	YAD and OTR screens with CCD cameras
	<b>transverse phase space (emittance)</b>	<b>Slit masks (EMSY1,2,3), quadrupoles, tomography module</b>
	longitudinal profile	Radiators (straight section) + streak read-out, upcoming – Transverse Deflecting Cavity
	<b>longitudinal phase space</b>	<b>Radiators (dispersive arms) + streak read-out, upcoming – Transverse Deflecting System (TDS)+HEDA2 (slice energy spread)</b>
slice emittance	HEDA with booster off-crest, upcoming → TDS+HEDA2	

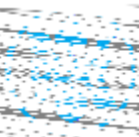
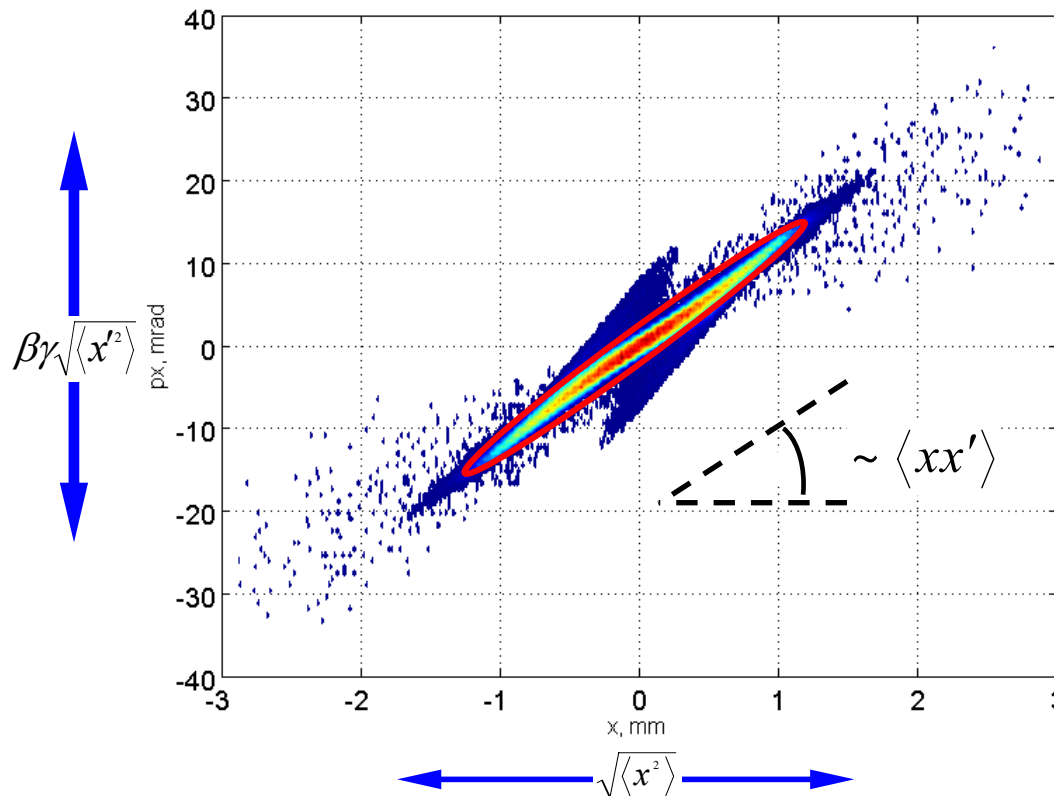


# Transverse Beam Emittance

PDF  $f_6(x, p_x, y, p_y, z, p_z) \longrightarrow f_2(x, p_x \propto \beta\gamma x')$

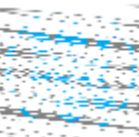
Normalized transverse emittance

$$\varepsilon_{nx} = \sqrt{\langle x^2 \rangle \langle p_x^2 \rangle - \langle xp_x \rangle^2} \longrightarrow \varepsilon_{nx} = \beta\gamma \sqrt{\langle x^2 \rangle \langle x'^2 \rangle - \langle xx' \rangle^2}$$



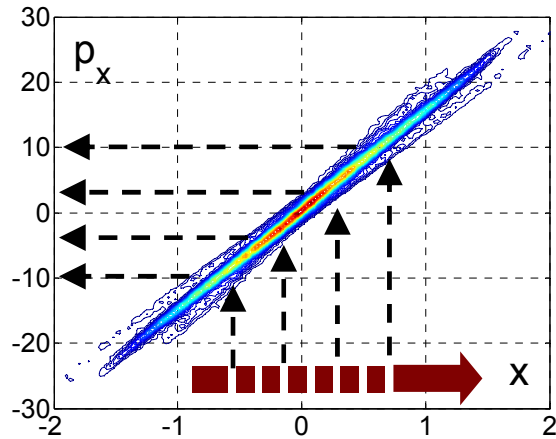
# Transverse emittance measurements at PITZ

- > Slit method
- > Quad(s) scan
- > Transverse phase space tomography
- > Slice emittance:
  - Booster off-crest → HEDA
  - Upcoming TDS

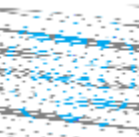
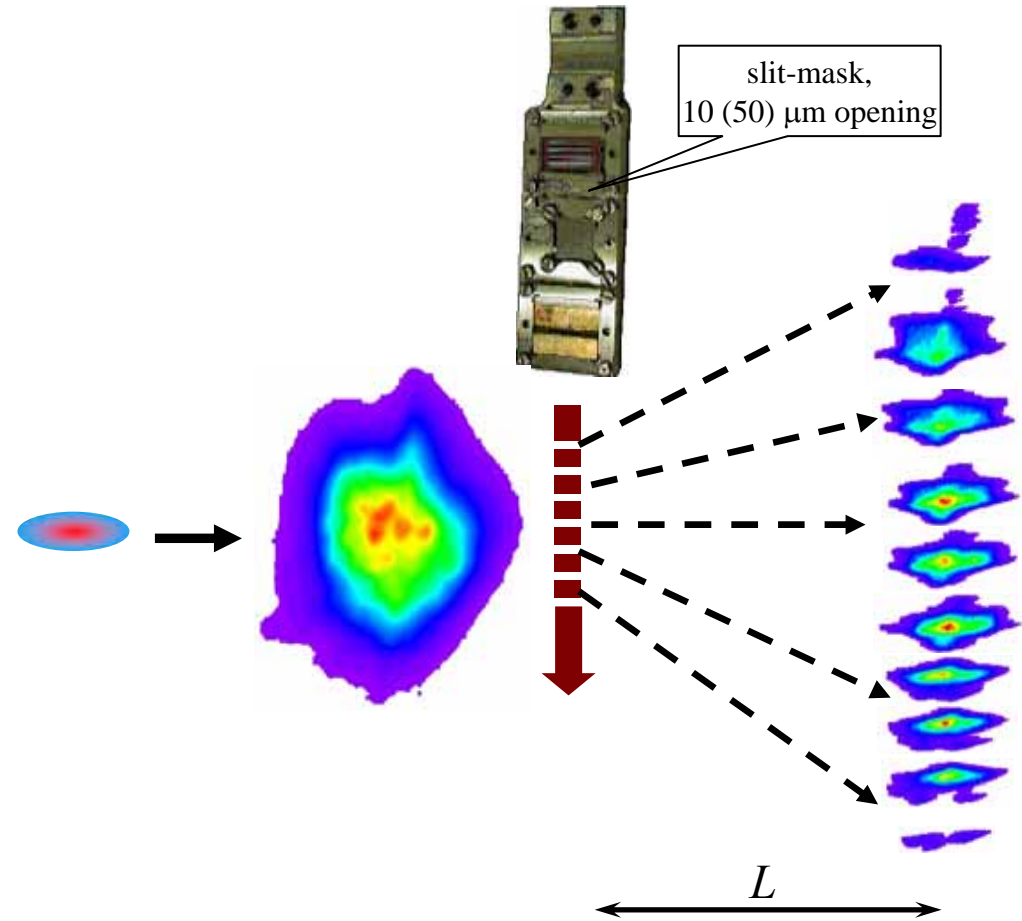


# Slit scan technique at PITZ

EMSY = Emission Measurement System

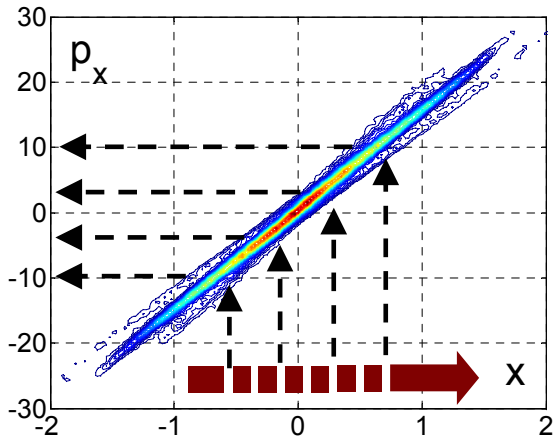


Transverse phase space reconstruction



# Slit scan technique at PITZ: sheared emittance

EMSY = Emittance Measurement SYstem



Transverse phase space reconstruction

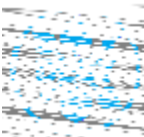
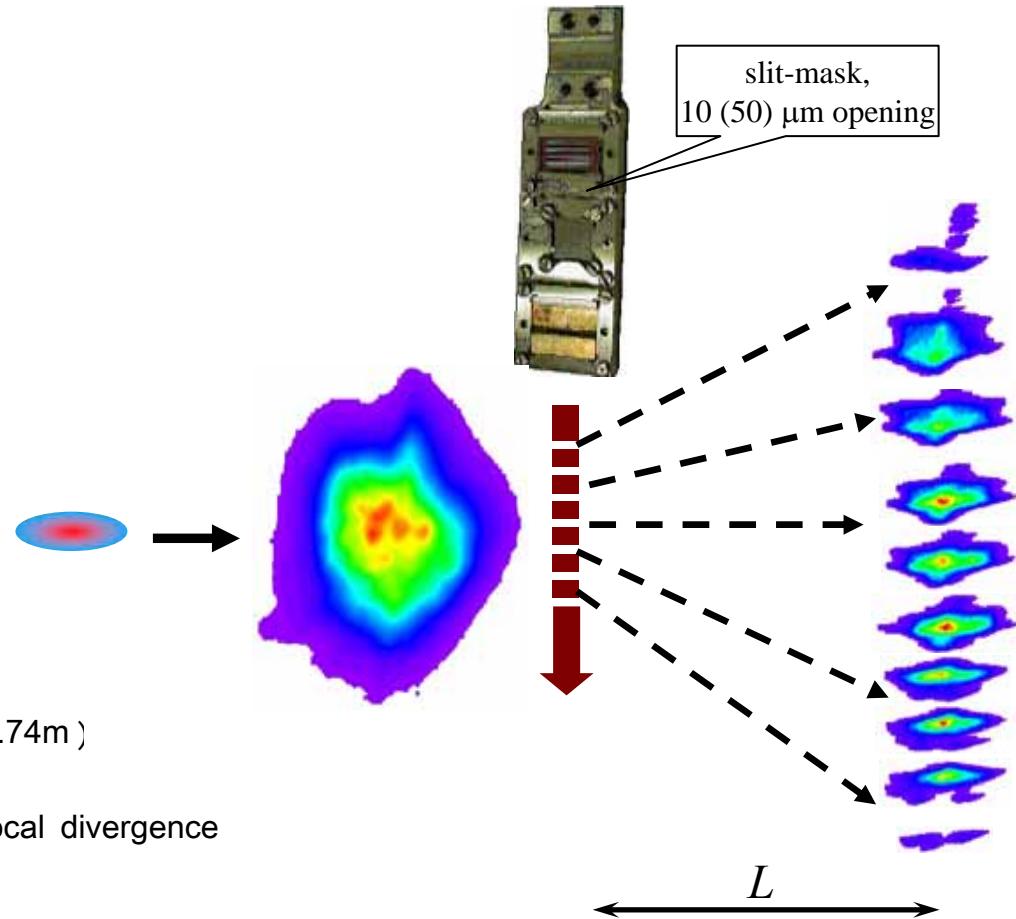
$$\mathcal{E}_{x,n}^{sheared} = \beta\gamma \cdot X_{rms} \cdot X'_{rms}$$

$X_{rms}$  - RMS size of full beam at EMSY station (e.g.  $z = 5.74\text{m}$ )

$$X'_{rms} = \frac{1}{L} \sqrt{\frac{\sum_{i=1}^n w_i \cdot (X_{rms}^{beamlet})_i^2}{\sum_{i=1}^n w_i}} \quad \text{- uncorrelated local divergence}$$

$X_{rms}^{beamlet}$  - RMS size of the beamlet image

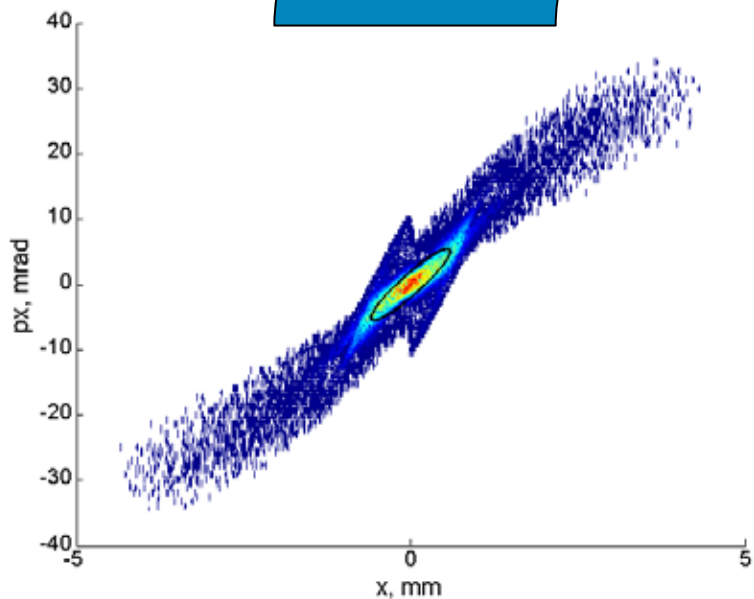
$L$  - distance from slit location to the beamlet collector screen



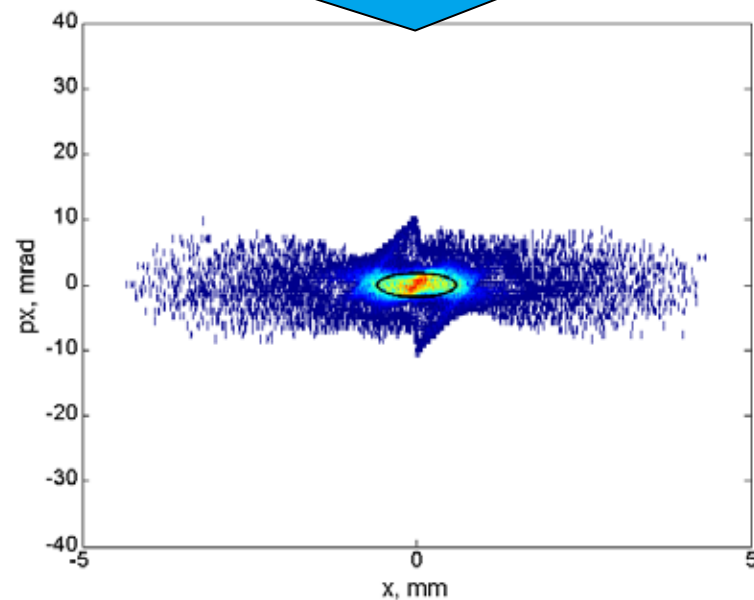


# Transverse phase space. Removing correlations

$$\sigma_{X'} = \frac{1}{L} \sqrt{\frac{\sum_{n=1}^{Nsl} w_n \cdot (\sigma_{X,n}^{BL})^2}{\sum_{n=1}^{Nsl} w_n}}$$

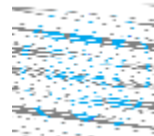


$$\mathcal{E}_{x,n} = 1.16 \text{ mm mrad}$$



$$\mathcal{E}_{x,n}^{sheared} = 1.03 \text{ mm mrad}$$

Phase space (nonlinear) correlations should be taken into consideration for the emittance calculations!



# Slit scan technique at PITZ: evolution

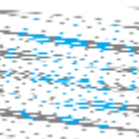
- > ~2002-2003 rough divergence estimation using center beamlet, 8 bit camera
- > 2003-2005 sheared emittance estimation using 3 slit positions (0; +/- 0.7\*sigmaX), 8-bit camera
- > 2005-2008 – “manual” scan (~200um step) → phase space reconstruction, 12-bit camera
- > 2009-2011 – automated synchronized slit scan with adjustable scan speed → phase space “on-line”, 12-bit cameras, zoom option, scale procedure

## The emittance measurement procedure at PITZ:

- under permanent improvement in terms of resolution and sensitivity
- as conservative as possible (**100% rms emittance**)!

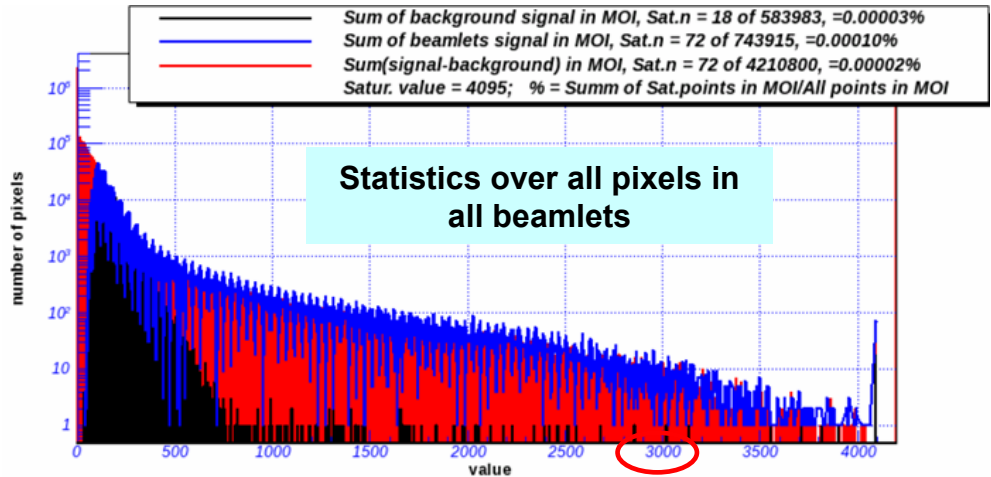
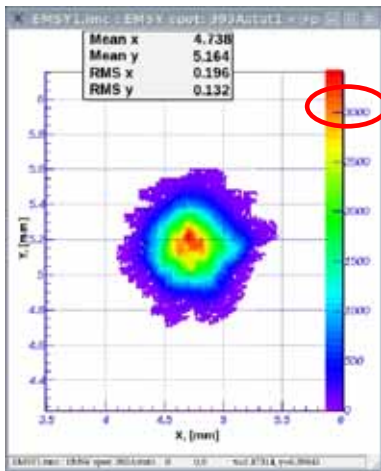
*!NB: measured emittance numbers are permanently **reducing** as a result of machine upgrades and extensive optimization*

*“we are measuring more and more of less and less...”*



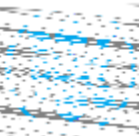
# Beam(let) image measurements

- > 12-bit camera is important!
- > Quality criteria: max bit  $\geq 3000$  (at least from  $4095=2^{12}-1$  max)
  - Adjustment of the camera gain G and the number of pulses NoP in a pulse train including camera gating to use the camera dynamic range as much as possible
  - For the beamlet collection -> auxiliary histogram -> at least several bits of some beamlets with an intensity of  $\geq 3000$



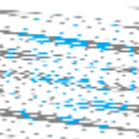
**using advantage of the long pulse operation!**

- > Image filtering
  - 3-sigma filter
  - Bkg-subtraction
  - X-ray filter
  - MOI=mask of interest at the beamlet collector screen



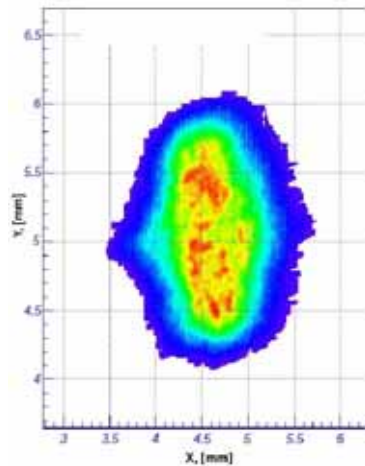
# Slit scan technique at PITZ: how it works now

- > Setup the machine
  - laser temporal and transverse
  - laser BBA at the cathode
  - gun phase
  - bunch charge
  - booster phase and gradient – beam energy (longitudinal momentum)
- > For a chosen main solenoid current (bucking in compensation)
  - Beam transverse distribution (rms size) at EMSY → 12-bit camera!; frames=50xSignal+50xBkg (laser shutter closed) with adjusted camera gain G and NoP
  - Beam transverse distribution at beamlet collection screen for MOI → 12-bit camera! frames=50xSignal+50xBkg (laser shutter closed) with adjusted camera gain G and NoP
  - Slit scan (typical speed 0.1-0.5mm/sec) with simultaneous beamlet image taking. Synchronization of the slit position and the frame acquisition (10Hz!) with adjusted camera gain G and NoP
  - Slit scan with closed laser shutter for the average bkg calculation
- > Transverse phase space reconstruction and emittance calculations
  - Phase space linear shift to take the slit position into account
  - Scaling procedure (more details in the next slide)
- > Error analysis (systematic and statistics – e.g. 3x5)

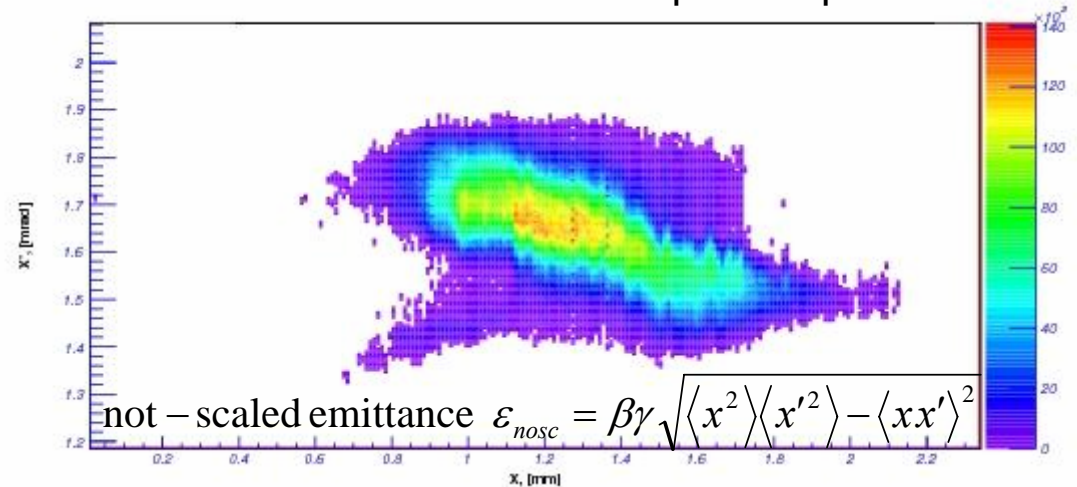


# Slit scan technique at PITZ: scale procedure

measured beam at EMSY screen



measured transverse phase space



$X_{rms}^{EMSY}$

← X-projection

≠

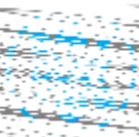
X-projection →

$\sigma_{x0} = \sqrt{\langle x^2 \rangle}$

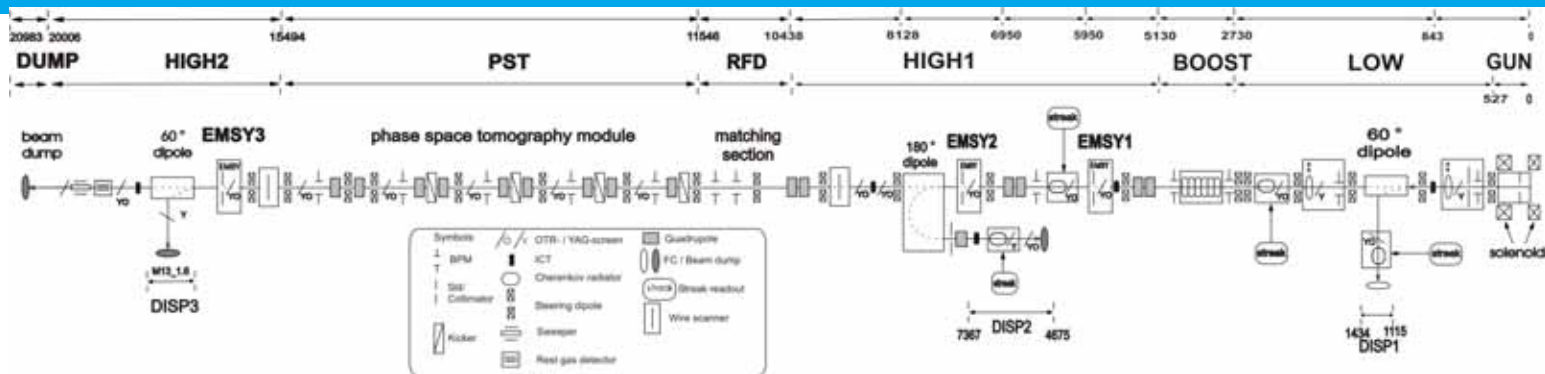
$$\text{scale factor } SF = \frac{X_{rms}^{EMSY}}{\sigma_{x0}} > 1$$

$$\text{scaled emittance } \epsilon_{sc} = \epsilon_{nosc} \cdot SF$$

**scale factor** introduced to correct for low intensity losses from beamlet measurements



# Photo injector parameters to be optimized



## Photo injector parameters:

- to be varied and optimized
- to be adjusted and controlled

### Gun:

- $E_{cath} = 60 \text{ MV/m}$  (fixed)
- **Launch rf phase ~on-crest**
- **Laser BBA**
- **RF pulse duration and FB**

### Solenoid:

- **$I_{main} = \text{main solenoid}$**
- Compensating  $I_{buck}$
- **Solenoid BBA**

### Booster cavity (CDS):

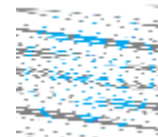
- $E_{max}$
- **RF phase ~on-crest**
- **RF pulse length**

### Cathode laser:

- **Transverse profile and size  $X, Y_{rms}$**
- **Temporal profile  $\rightarrow \sim 20..22 \text{ ps}$ , short rt**
- **Pulse train length (NoP)**

### Electron bunch:

- **Charge/bunch**
- **Trajectory (e.g. bypass the vacuum mirror)**

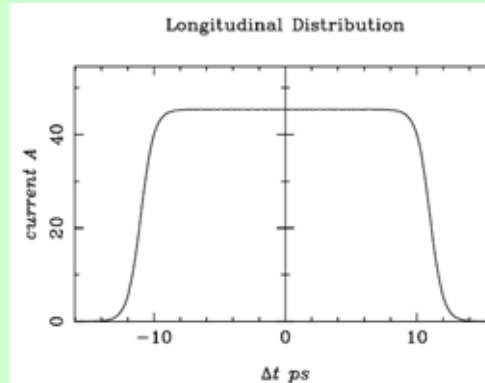


# Beam dynamics simulations for PITZ-1.8

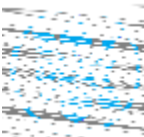
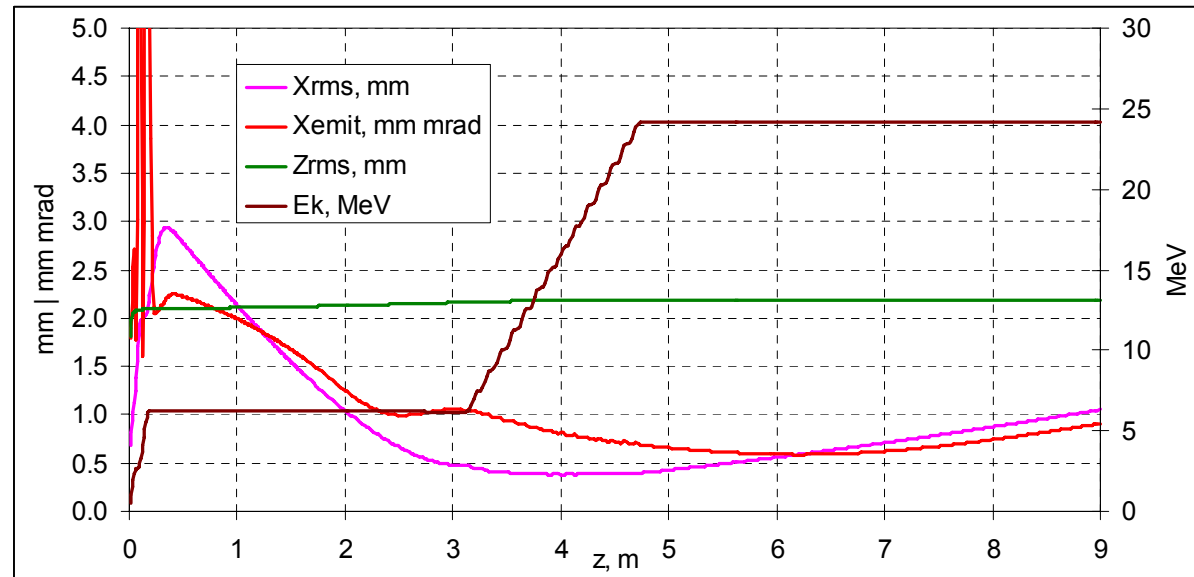
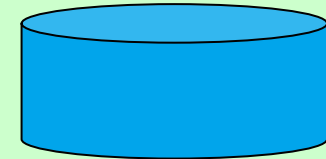
## Optimized machine setup (ASTRA simulations)

	parameter	unit	value
cathode laser	temporal	profile	flat-top
	transverse	distribution	rad.homogen
	rt/FWHM\ft	ps	2/22\2
	XYrms	mm	0.401
	Ek	eV	0.55
	th.emit.	mm mrad	0.34
RF-gun	Ecath	MV/m	60.58
	phase	deg	-1.116
	maxBz	T	-0.22808
CDS boost	maxE	MV/m	20.6
	phase	deg	0
e-beam @EMSY1	charge	nC	1
	momentum	MeV/c	24.64
	proj.emit.	mm mrad	<b>0.60</b>
	th./proj.em.	%	<b>57%</b>
	<sl.emit.>	mm mrad	0.53

## Laser distributions at the cathode

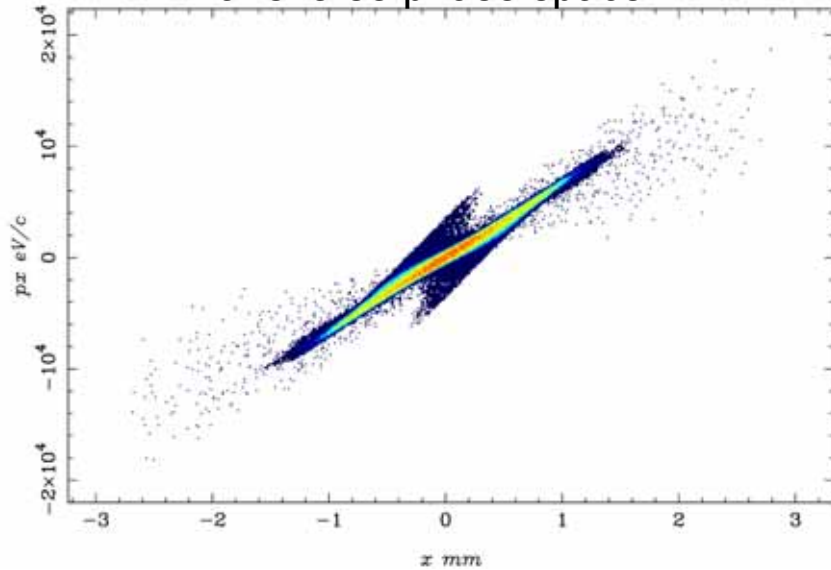


Transverse distribution  
radial homogeneous

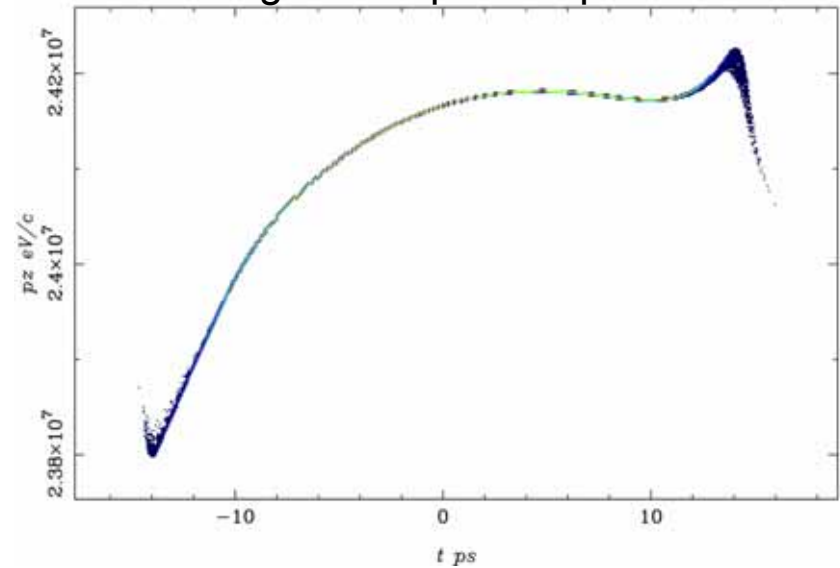


# Beam dynamics simulations for PITZ-1.8: e-beam at EMSY

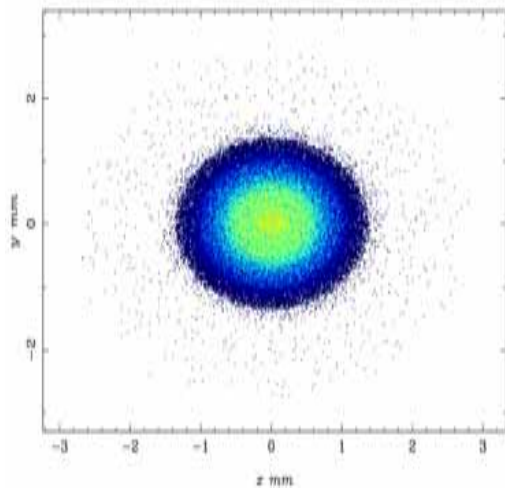
Transverse phase space



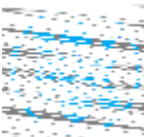
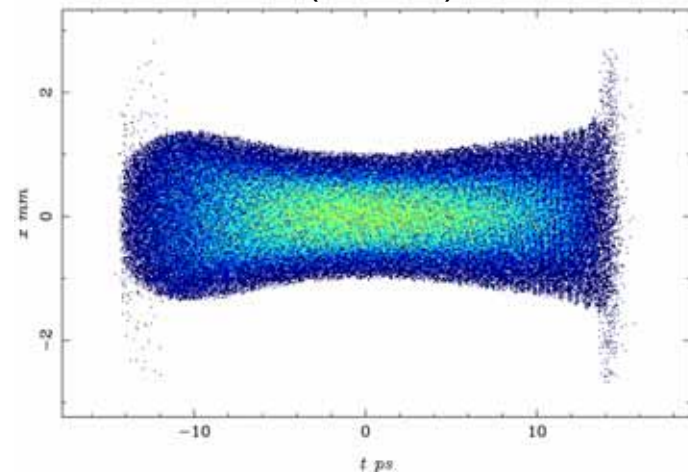
Longitudinal phase space



Transverse X-Y distribution



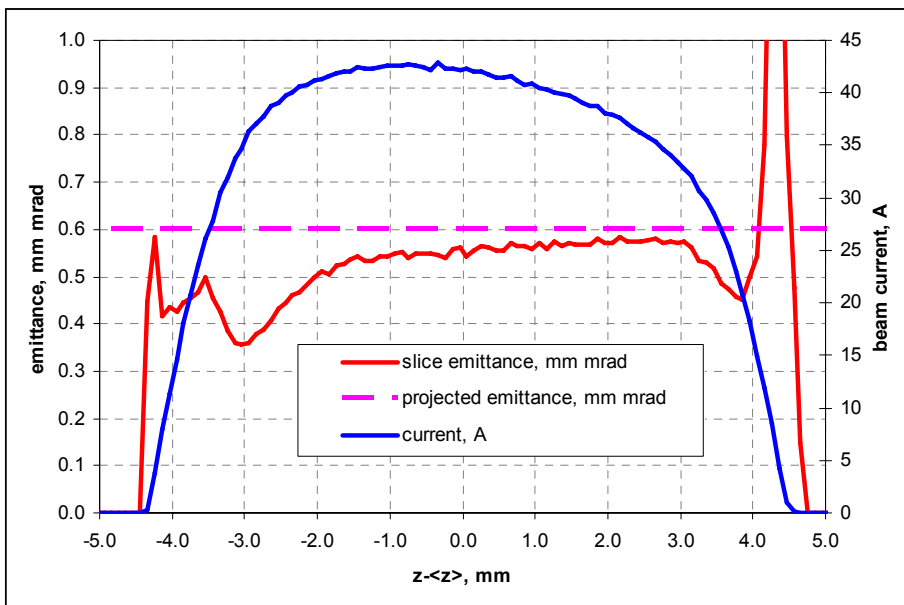
Side (time-X) view



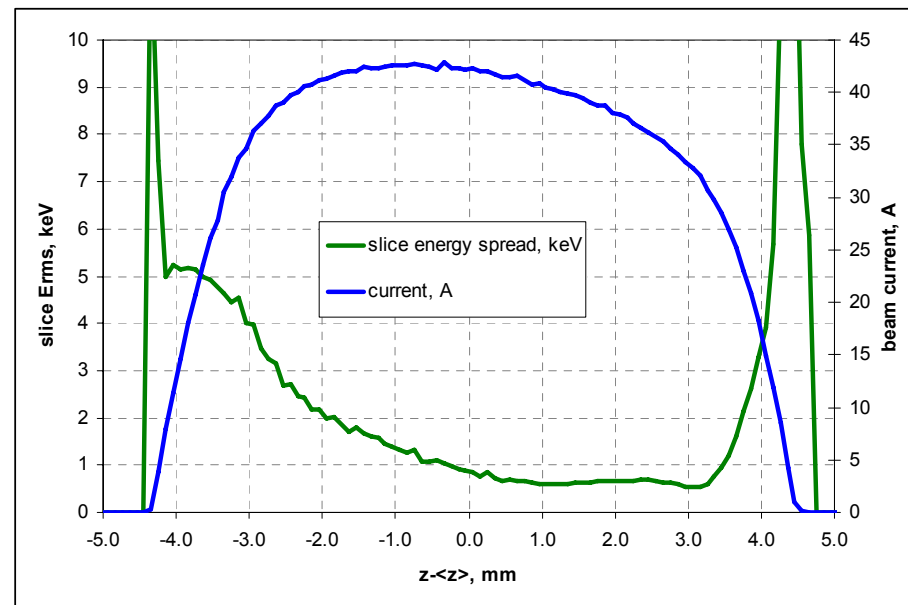


# Beam dynamics simulations for PITZ-1.8: electron beam at EMSY – slice parameters

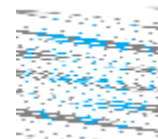
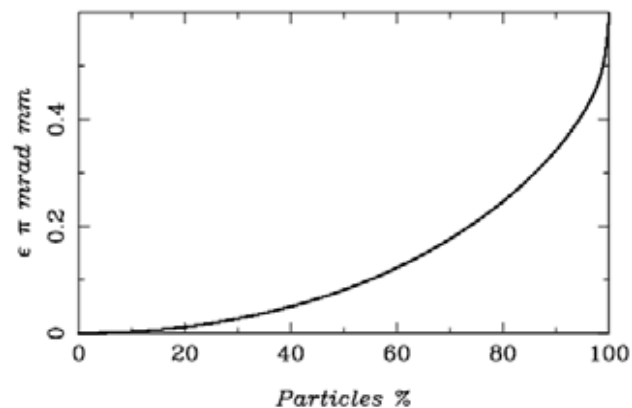
## Slice emittance



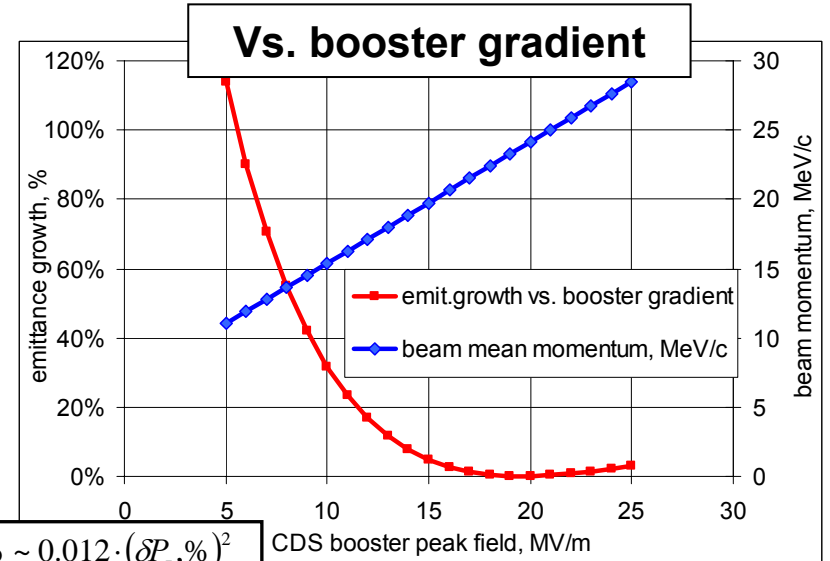
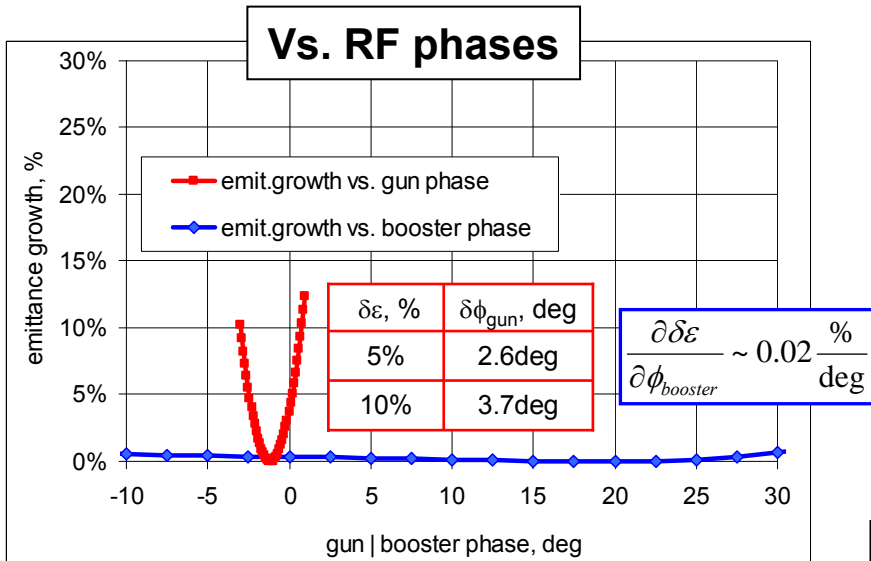
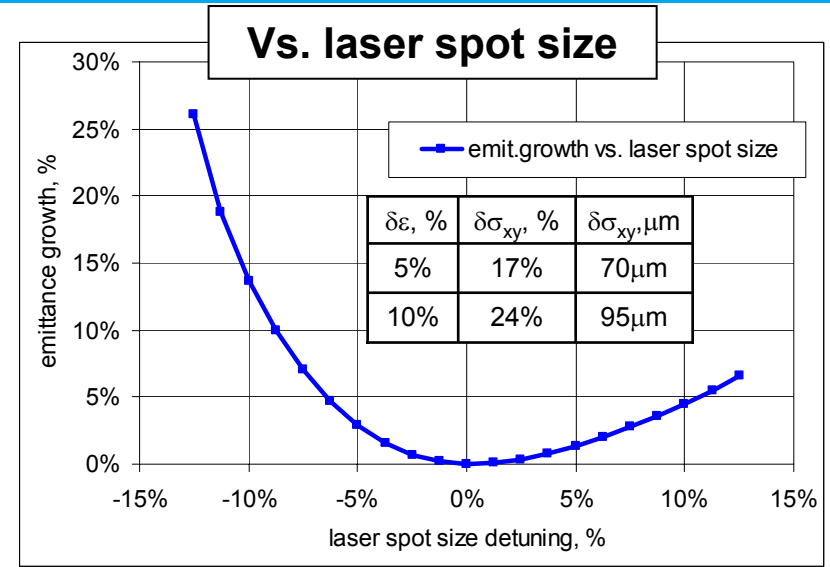
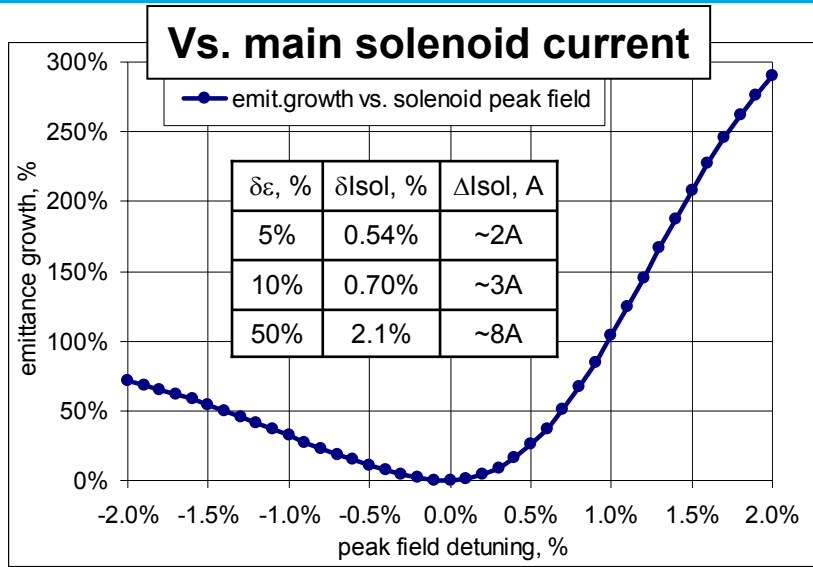
## Slice energy spread



## Core emittance



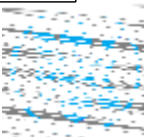
# Beam dynamics simulations for PITZ-1.8: tolerances



$$\delta\epsilon, \% \sim 0.012 \cdot (\delta P_z, \%)^2$$

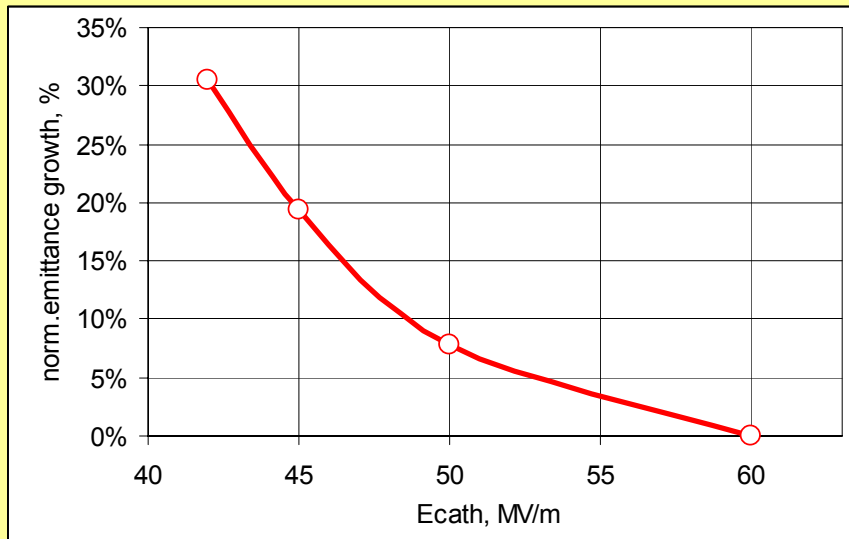
$$\delta\epsilon(P_z > 18 \text{ MeV}/c) < 5\%$$

CDS booster peak field, MV/m

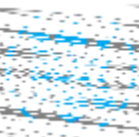
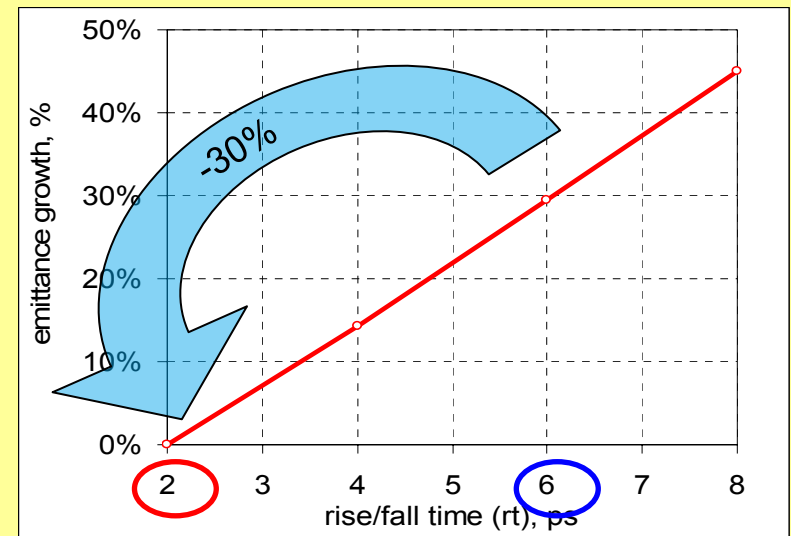


# Beam dynamics simulations for PITZ-1.8: imperfections

## Simulated emittance growth vs. gun gradient

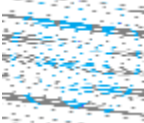
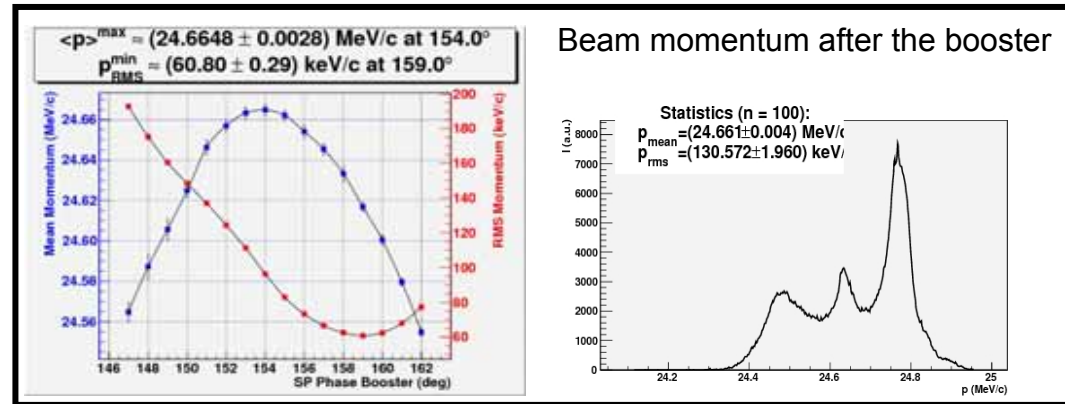
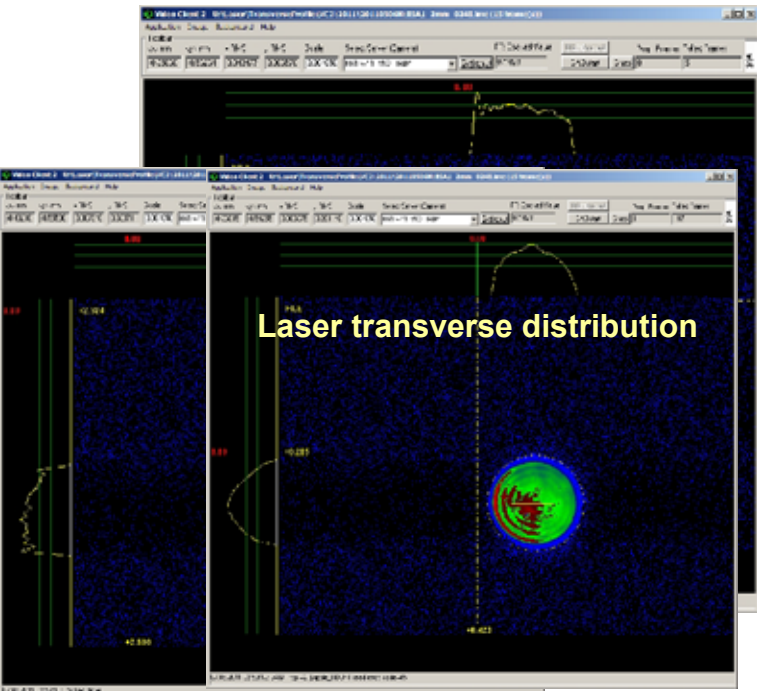
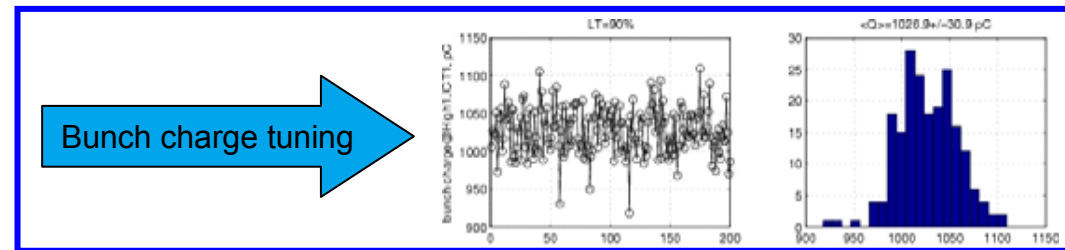
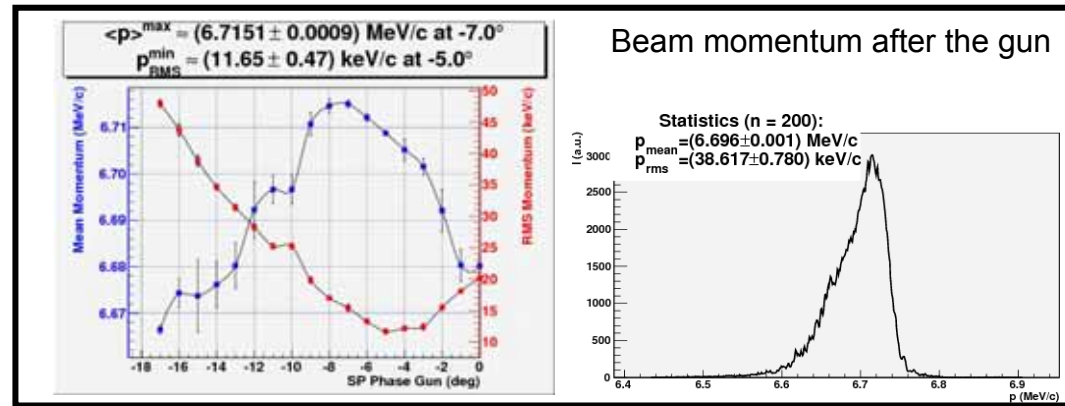
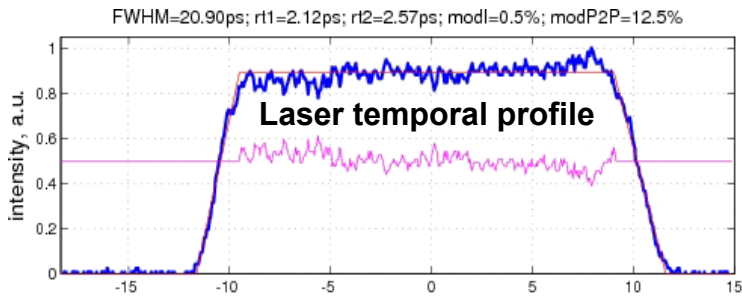


## Simulated emittance growth vs. cathode laser rise/fall time



# Emittance measurements at PITZ (typical solenoid scan)

Machine setup (07.05.2011M): BSA=1.2mm; gun=6deg off crest; 1nC; booster=on-crest



# Emittance measurements at PITZ: typical solenoid scan

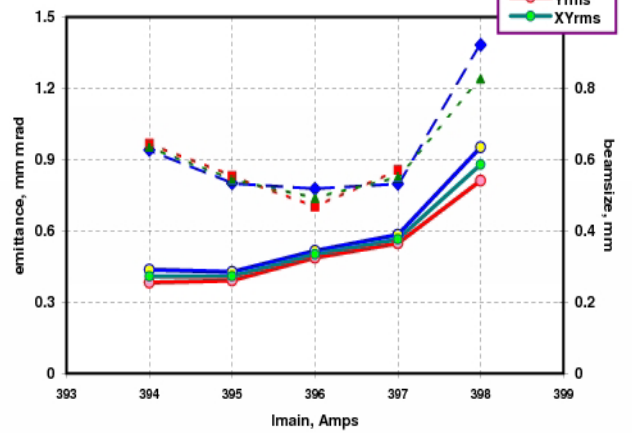
## 1) Solenoid scan for X and Y emittance

I <sub>main</sub> (A)	Xrms, mm	Yrms, mm	EmitX_2D, mm mrad	EmitY_2D, mm mrad	XYrms, mm	EMSY1 NoP	EMSY1 Gain	MOI NoP	MOI Gain	XBL NoP	XBL gain	EmitX_2D, mm mrad	EmitY_2D, mm mrad	XYrms, mm	YBL NoP	YBL gain	EmitXY_2D, mm mrad	EmitXY_2D, mm mrad	X-scale factor	Y-scale factor
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For all measurements f250 lenses and 2x2 binning were used

	398	0.635	0.541	1.383	0.905	0.586	3	20	2	20	26	20	1.113	1.049	25	20	1.241	0.974	1.5	1.3
397	0.389	0.365	0.798	0.632	0.377	1	24	1	23	14	20	0.856	0.798	13	20	0.826	0.710	1.3	1.2	
396	0.344	0.325	0.778	0.514	0.334	1	21	1	21	7	20	0.701	0.606	8	20	0.738	0.558	1.5	1.3	
395	0.285	0.261	0.800	0.477	0.273	1	17	1	18	5	20	0.831	0.732	7	20	0.815	0.591	1.7	1.4	
394	0.291	0.255	0.941	0.481	0.272	1	15	1	17	5	20	0.967	0.728	7	20	0.954	0.592	2.0	1.6	

Beam size and 2D emittance for BSA 1.2 mm, 1nC, gun of 06 deg from MMMG phase, booster on-crest



07.05.2011M: sol.scan:  
 Xemit | Yemit | XYemit  
 0.778 | 0.701 | 0.738

## 2) 3x3 statistics for the bes solenoid current

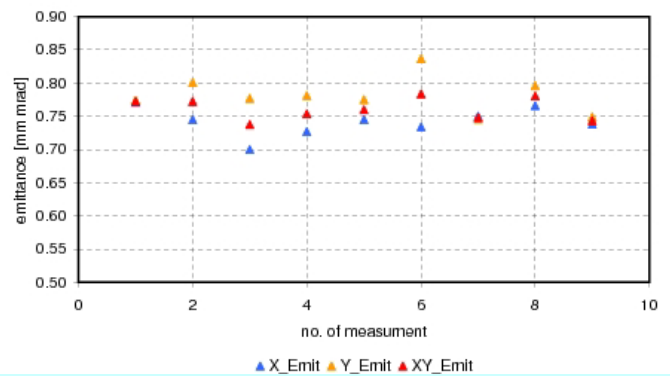
Solenoid 396 A

EMSY1 NoP	1	1	1
EMSY1 Gain	21	21	21
MOI NoP	1	1	1
MOI Gain	20	20	20
XBL NoP	5	7	6
XBL Gain	20	20	20
YBL NoP	8	10	9
YBL Gain	20	20	20

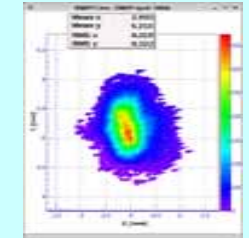
### 3x3 measurements

meas	beam size @ EMSY			X-emittance		Y-emittance		XYemit, scaled	XYemit, nonscaled
	X	Y	XY	scaled	nonscaled	scaled	nonscaled		
1	0.318	0.322	0.320	0.771	0.492	0.774	0.691	0.772	0.583
2	0.318	0.322	0.320	0.745	0.474	0.801	0.700	0.772	0.576
3	0.318	0.322	0.320	0.700	0.471	0.777	0.669	0.737	0.551
4	0.316	0.314	0.315	0.727	0.497	0.781	0.730	0.754	0.602
5	0.316	0.314	0.315	0.745	0.498	0.775	0.763	0.760	0.616
6	0.316	0.314	0.315	0.734	0.516	0.837	0.770	0.784	0.630
7	0.309	0.313	0.311	0.750	0.513	0.746	0.666	0.749	0.585
8	0.309	0.313	0.311	0.765	0.531	0.796	0.709	0.781	0.614
9	0.309	0.313	0.311	0.738	0.590	0.749	0.691	0.743	0.588

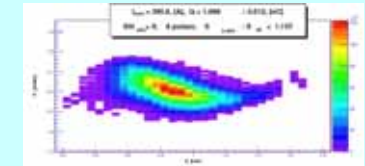
Mean	0.314	0.316	0.315	0.742	0.499	0.782	0.710	0.761	0.595
Std	0.004	0.004	0.004	0.021	0.019	0.028	0.037	0.017	0.022



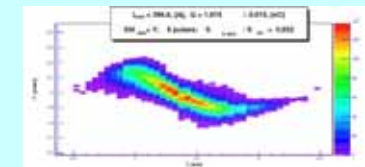
07.05.2011M: 3x3 stat:  
 Xemit=(0.742±0.021stat) mm mrad  
 Yemit=(0.782 ±0.028stat)mm mrad  
 XYemit=(0.761± 0.017stat)mm mrad



beam  
at EMSY:  
3x1



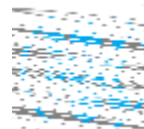
XPx:  
3x3



YPy:  
3x3

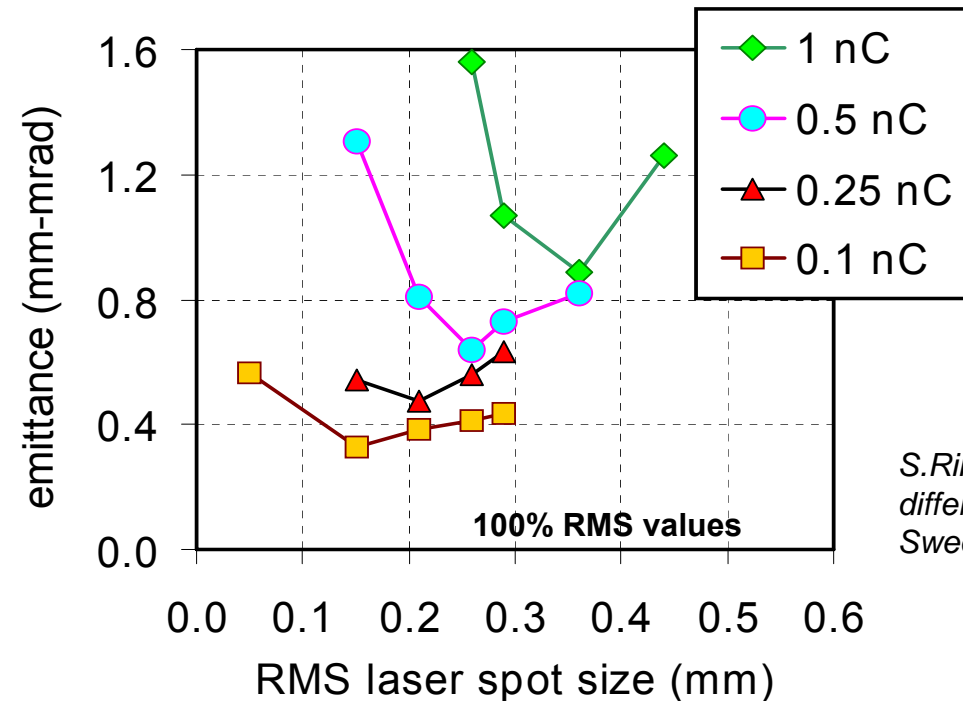


Geometrical averaged emittance:  $\epsilon_{xy} = \sqrt{\epsilon_x \epsilon_y}$



# Emittance for different charges for PITZ1.7 setup (2009)

- **Laser temporal profile:** flat-top, 23-25 ps (FWHM), 2-3 ps rise-time, 3-4 ps fall-time
- **Laser (rms) spot size:** 0.05 → 0.44 mm
- **Maximum gun momentum:** ~6.68 MeV/c
- **Gun phase:** +6 deg from maximum mean momentum gain phase
- **Booster phase:** max. momentum gain phase → ~14.5 MeV/c for 1 nC bunch charge  
→ ~12.3 MeV/c beam momentum for lower charges

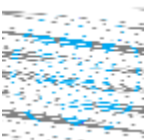


Measurements 2009				
Q (nC)	1	0.5	0.25	0.1
$\sigma_{xy}$ (mm)	0.36	0.26	0.21	0.15
$\epsilon_x$	0.72±0.01	0.53	0.42	0.29
$\epsilon_y$	1.09±0.02	0.77	0.53	0.37
$\epsilon_{xy}$	0.89±0.01	0.64	0.47	0.33

S.Rimjaem et al. "Measurements of transverse projected emittance for different bunch charges at PITZ", Proceedings of FEL2010, Malmö, Sweden, pp.410-413.

these results + experience from LCLS (only small degradation of slice emittance from gun to undulator) → **FEL can be operated with 14 GeV beam energy**

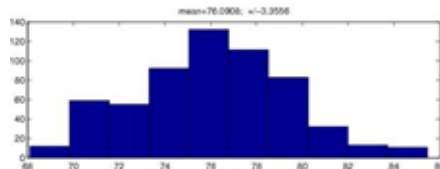
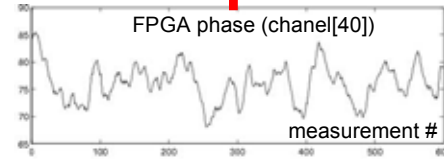
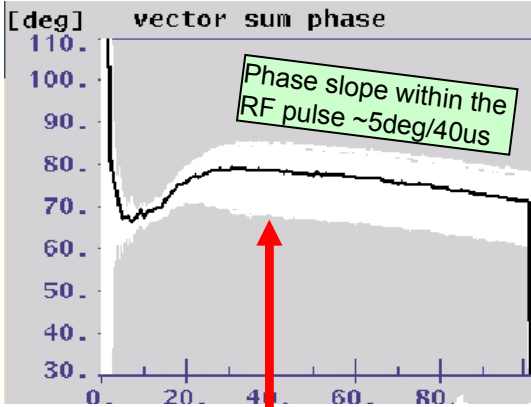
- **Gun now in operation at FLASH**
- But! Increase of measured emittance values due to phase jitter and slope over train! (especially for low charges)



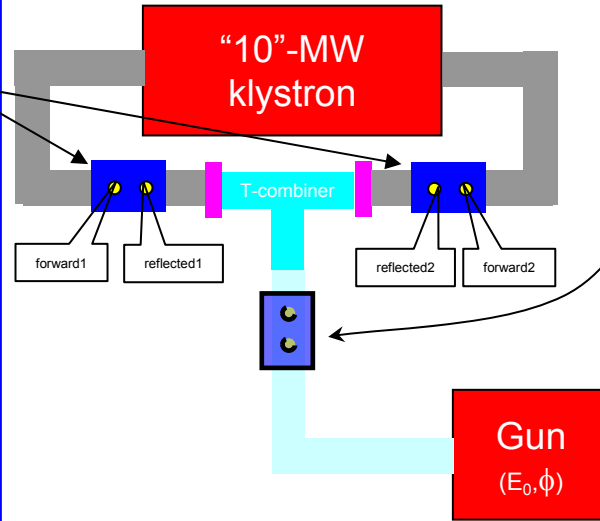
# Improvement of the RF gun phase stability

2009 (no FB)

FPGA phase, reconstructed from virtual ADC probes based on 2x5MW directional couplers



Phase fluctuations:  
 •10..15 deg (p-p)  
 •2..4 deg (rms)



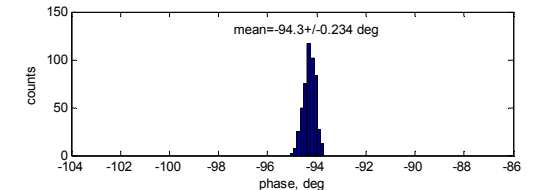
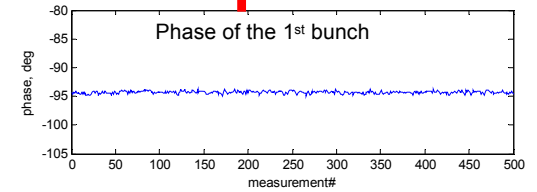
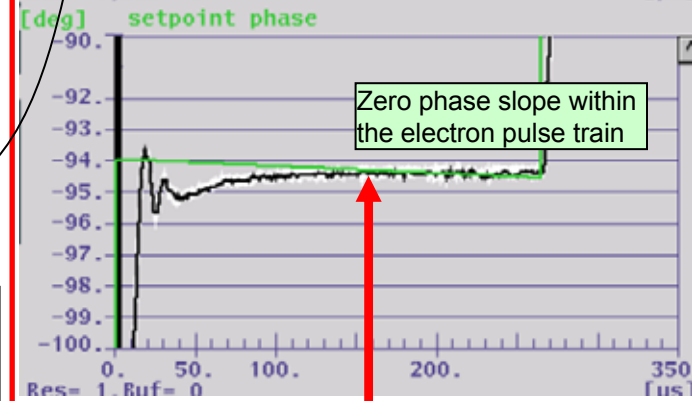
10-MW in-vacuum directional coupler installed since 2010



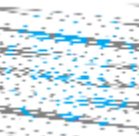
Manufacturer: Mega Industries, USA

2011 (FB is ON!)

FPGA phase, measured by 10MW in-vacuum directional coupler



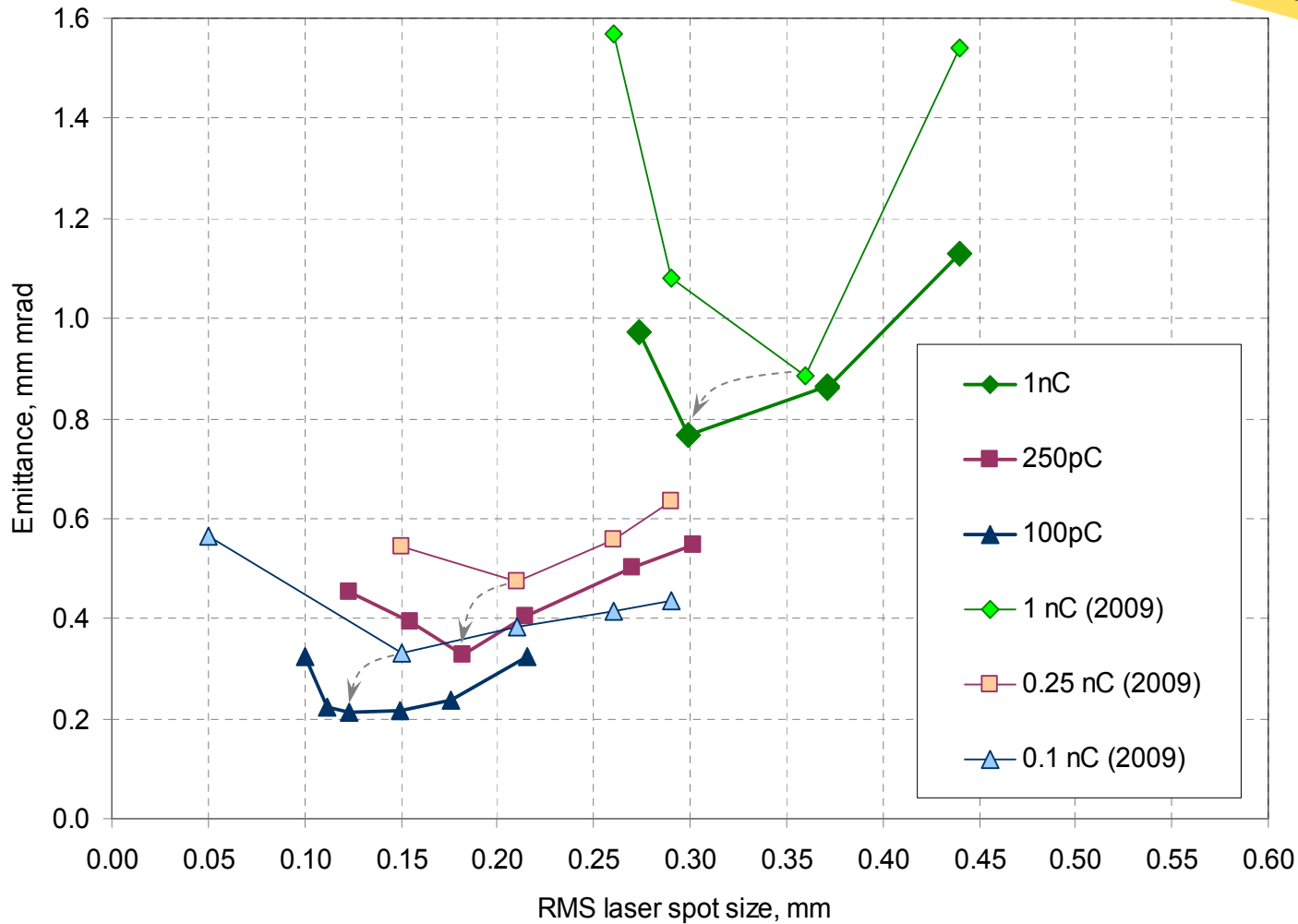
Phase fluctuations:  
 •1..1.5 deg (p-p)  
 •0.2..0.3 deg (rms)



# Projected emittance measurements at PITZ 2009-2011

## Emittance optimization in 2009-2011

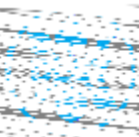
preliminary



> beam energy increased to ~25MeV (2009:<15MeV)

> slightly different transverse laser shape

> **SIGNIFICANTLY improved RF phase stability !!**

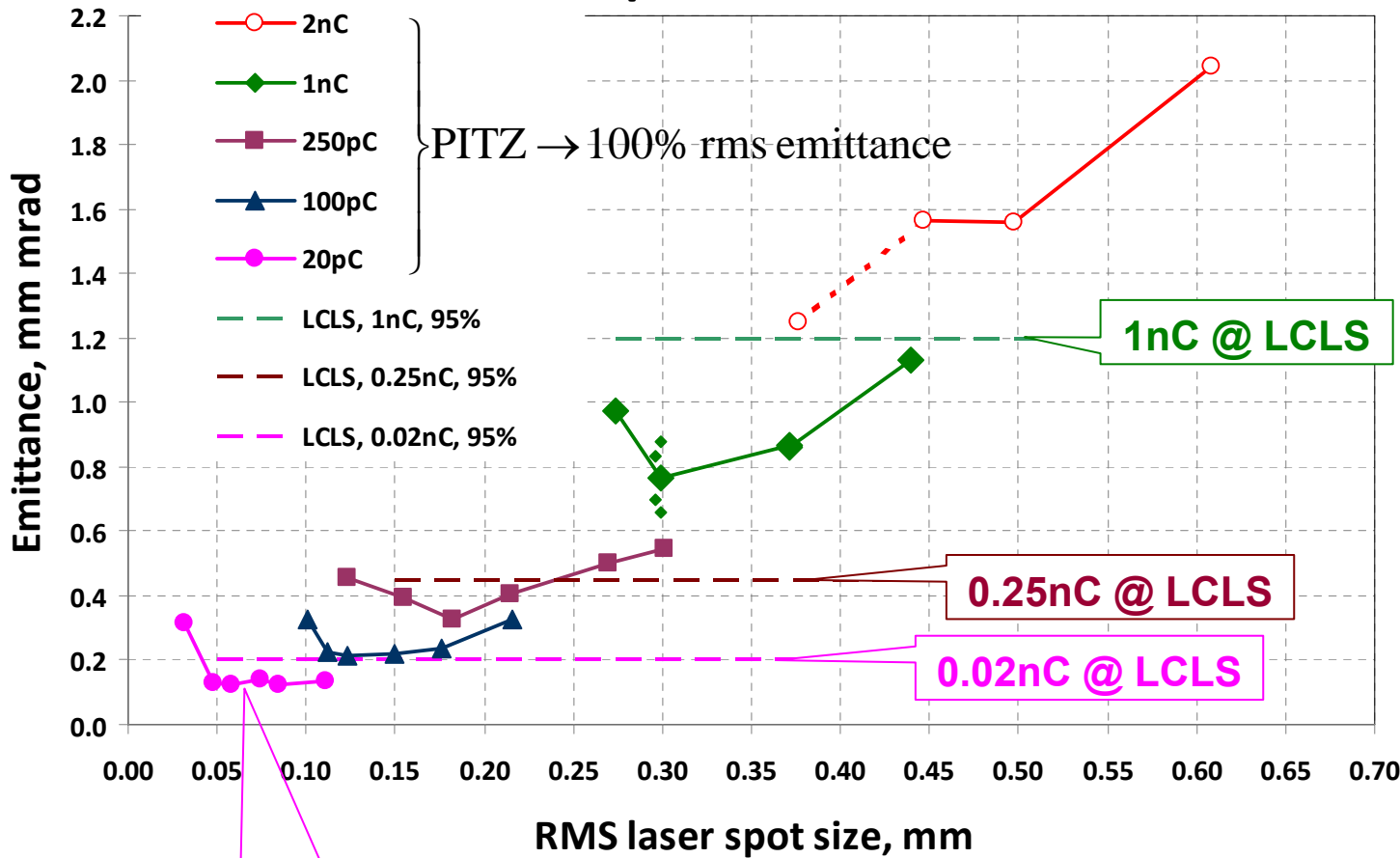




# Projected emittance measurements at PITZ 2011

preliminary

## Emittance optimization in 2011



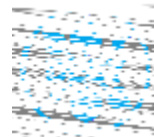
1nC @ LCLS

0.25nC @ LCLS

0.02nC @ LCLS

upto 200 pulses/train used!

**PITZ is setting a new benchmark for minimum emittance at a given charge + capable of operation at high duty cycle!!**

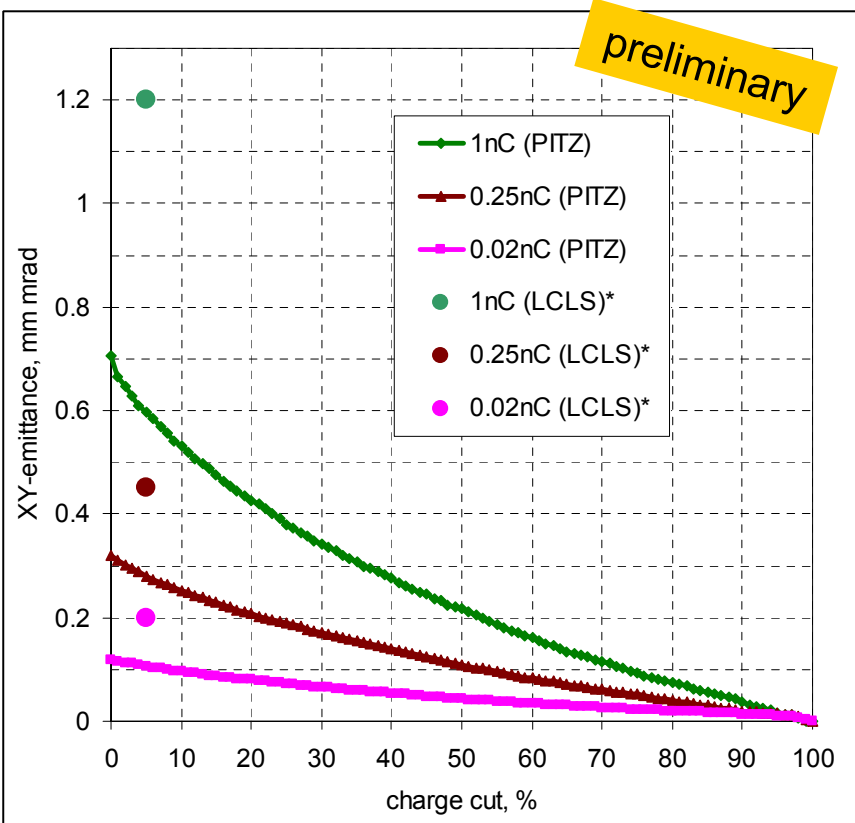


# Projected emittance measurements at PITZ 2011

preliminary

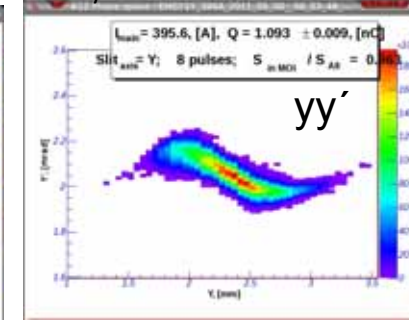
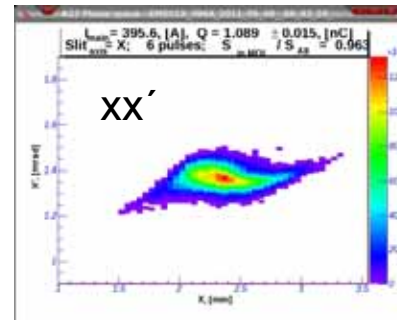
Q, nC	shift statistics	laser BSA / $\sigma_{xy}$ mm	$\phi_{gun}$ / $\phi_{booster}$ deg	Pz(after gun) / Pz(final), MeV/c	Beam at EMSY1	X-phase space	Y-phase space	Xemit Yemit XYemit, mm mrad	Remark
<b>2.0</b>	03.05.20	1.5	6	6.69				<b>1.239</b>	
	11M-A	/	/	/				<b>1.267</b>	
	3x3 stat	0.377	0	24.79				<b>1.251</b>	
<b>1.0</b>	07.05.20	1.2	6	6.67				<b>0.724</b>	Same scale span for phase spaces
	11N	/	/	/				<b>0.603</b>	
	3x3 stat	0.300	0	24.67				<b>0.661</b>	
<b>0.25</b>	06.04.20	0.7	0	6.70				<b>0.367</b>	
	11N	/	/	/				<b>0.292</b>	
	3x5 stat	0.182	0	25.07				<b>0.328</b>	
<b>0.1</b>	12.04.20	0.5	0	6.71				<b>0.281</b>	
	11M	/	/	/				<b>0.160</b>	
	3x3 stat	0.123	0	24.91				<b>0.212</b>	
<b>0.02</b>	30.04.20	0.35	0	6.76				<b>0.111</b>	Zoomed phase spaces
	11A	/	/	/				<b>0.133</b>	
	2x3+4stat	0.085	0	23.68				<b>0.121</b>	

# Emittance measurements at PITZ 2011: core emittance

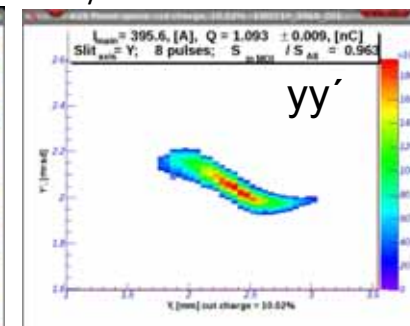
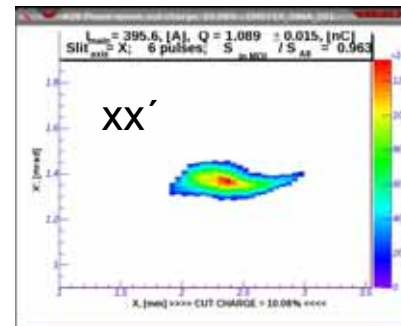


\*LCLS results: projected emittance, 95% RMS values.  
D. Dowell + P. Emma, priv. commun. + FEL2009

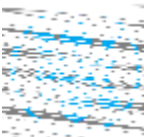
**100% of 1nC:**  $\epsilon_x = 0.77$  mm mrad,  $\epsilon_y = 0.65$  mm mrad



**90% of 1nC:**  $\epsilon_x = 0.58$  mm mrad,  $\epsilon_y = 0.49$  mm mrad

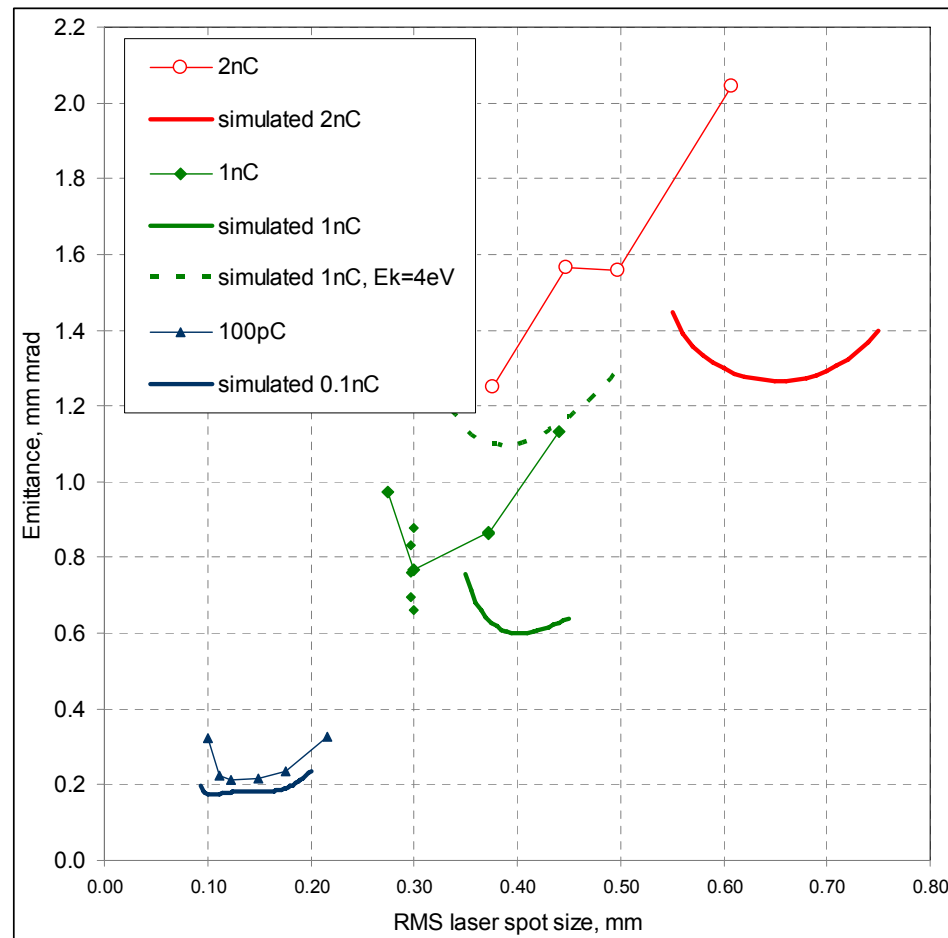


Q, nC	LCLS (95% RMS values)*		PITZ (100% RMS)	PITZ (95% RMS)
	projected $\epsilon$	slice $\epsilon$	projected $\epsilon$	projected $\epsilon$
1	1.2	0.9	<b>0.71</b>	<b>0.60</b>
0.25	0.45	0.4	<b>0.32</b>	<b>0.28</b>
0.02	0.2	0.14	<b>0.12</b>	<b>0.11</b>



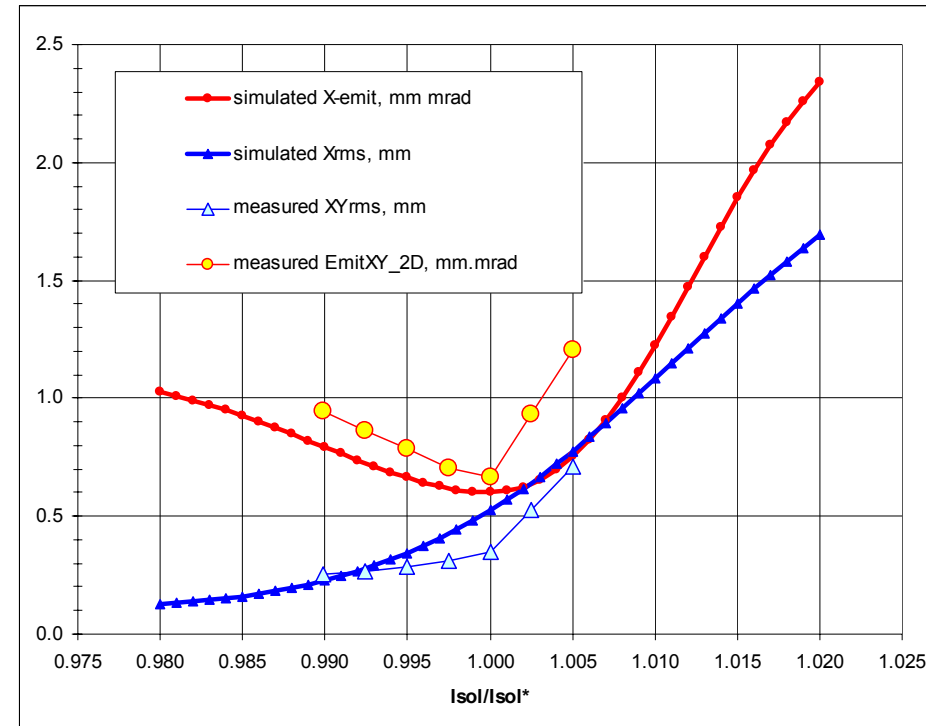
# Emittance at PITZ: measurements vs simulations

## Various bunch charges



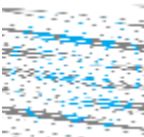
Only for 0.1nC rather good agreement on an optimum rms laser spot size!

## Solenoid scan for 1nC



Optimum simulations vs. optimum measurements, but different laser rms spot size!!

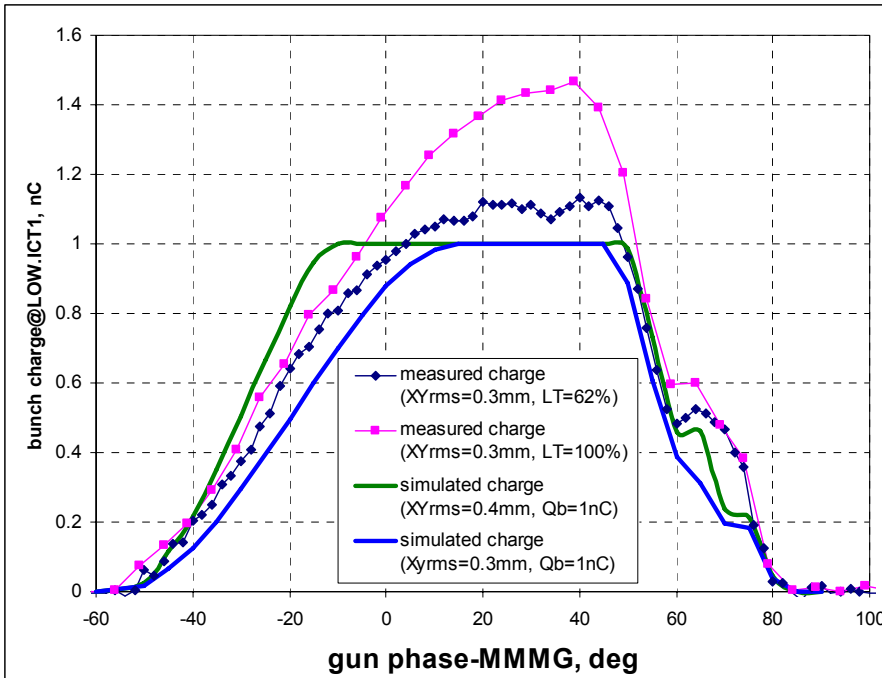
**Experimental optimization is very important!**



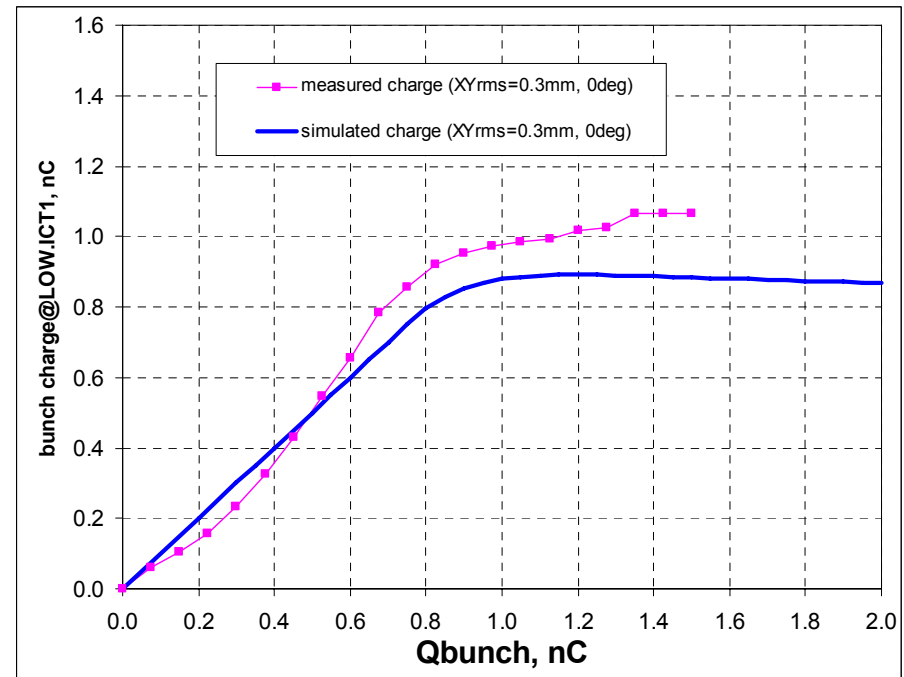
# Emittance at PITZ: measurements vs simulations

Reasons of the discrepancy? → **emission**

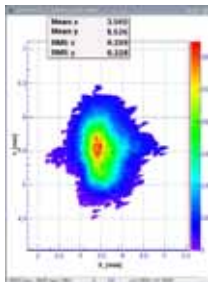
Measured and simulated Schottky scans



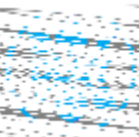
Measured and simulated laser energy scan



ASTRA: Qbunch → initial bunch charge at the cathode  
Measurement: →  $a \cdot LT \sim$  laser energy



?Electron beam x-y asymmetry -> scale factor  $SF_x$  upto 2..3



# Rough schedule for the future

**PITZ** delivered decisive contributions to FLASH and XFEL and can also be a **goldmine** in future:

## Timeline:

- > Jun.`11-Nov.`11:  
Shutdown for installing  
TDS, HEDA2 and  
Toshiba klystron
- > Dec.`11-Jun.`12: **Run**
- > **July`12**: start to install  
and condition general  
purpose **XFEL-FLASH-  
PITZ-Gun**

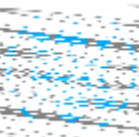
## Scientifics:

**Bread & Butter** (ongoing, partially done) :

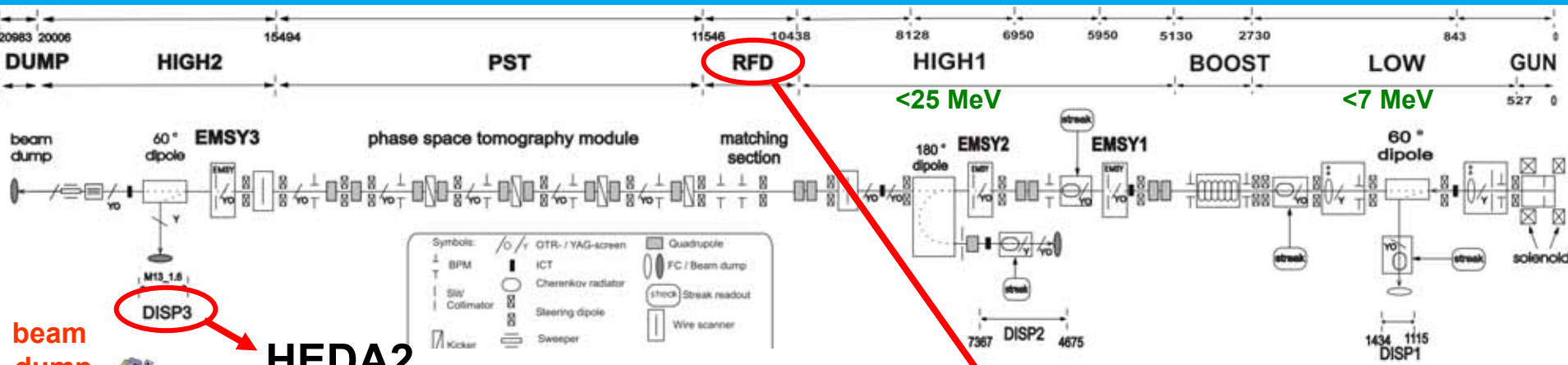
- > Characterizing XFEL gun, later higher rep.rate
- > XFEL test bed, e.g. laser system (4.5MHz + therm. lens), beam diagnostics

**New tasks/options** (honey from low emittance, high duty cycle, flexibility @PITZ) :

- > Optimizing new operation modes: **ultra short bunches** (single spike lasing)  
→ together with HH: S2E simulations, exp. tests, diagnostics  
→ **3D elliptical laser pulses** on cathode: lower  $\epsilon$ , halo, bunch length
- > E.g. participation in **Plasma Acceleration**



# PITZ setup: now and upgrades during this year



## HEDA2

→ together with TDS: measure slice momentum spread down to 1 keV/c

## Transverse Deflecting Structure (TDS)

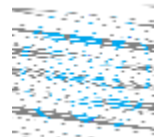
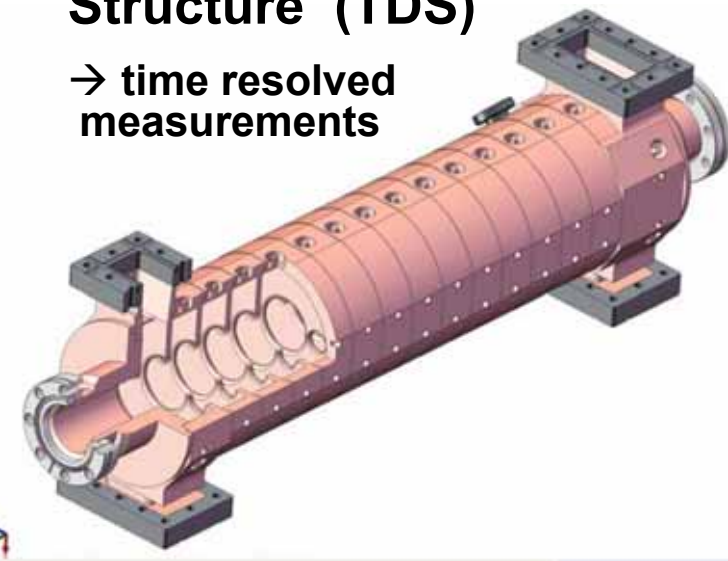
→ time resolved measurements

beam dump

DISP3.Scr2

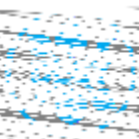
electron beam

DISP3.Scr1



# Summary

- > PITZ = benchmark for high brightness electron sources:
  - specs for the European XFEL have been demonstrated (emittance  $<0.9$  mm mrad at 1nC)
  - beam emittance has also been optimized for a wide range of bunch charge (20pc...2nC)
  - rather high duty factor (average power, long pulse trains) in a stable operation
- > The main focus at PITZ  $\rightarrow$  small emittance electron beams. To reach this:
  - high gun gradients
  - laser temporal shaping
  - machine stability
  - extensive machine optimization
- > Emittance measurement procedure
  - nominal method  $\rightarrow$  single slit scan
  - as conservative as possible  $\rightarrow$  100% rms emittance
  - continuous improvement of the procedure
- > PITZ serves also as a benchmark for theoretical understanding of the photo injector physics (beam dynamics simulations vs. measurements)





# The End

